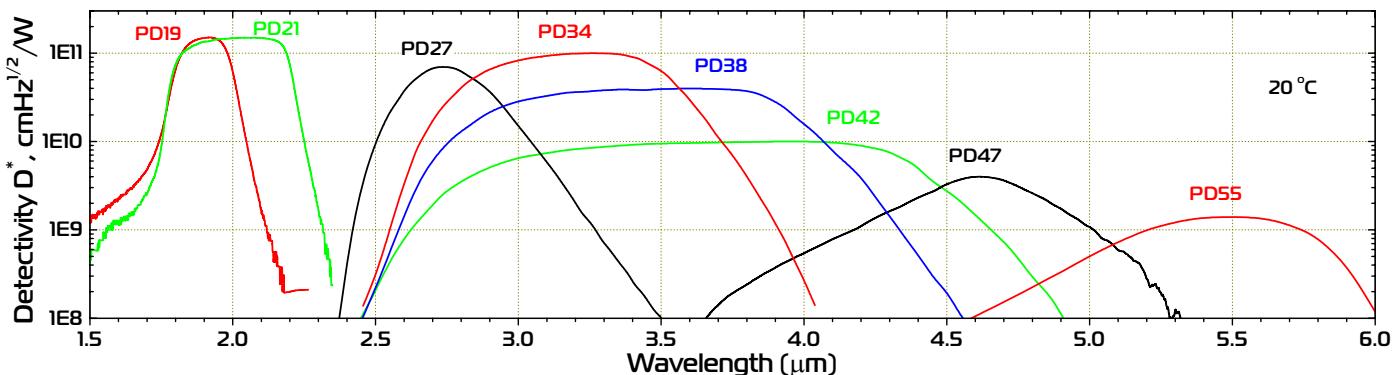


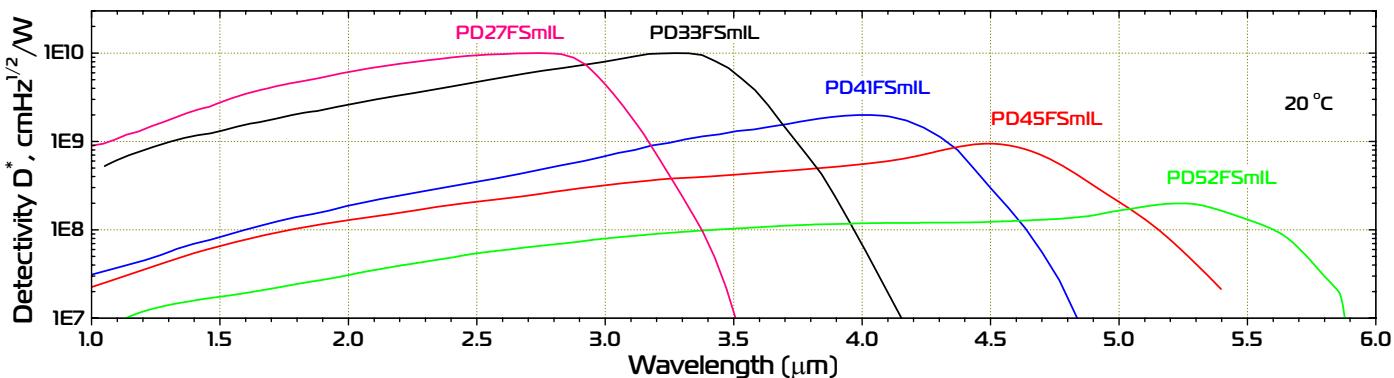
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	Peak wavelength	Spectral range	Sensitive area	Angle of view	Package	Detectivity
	$\lambda_{\max}, \mu\text{m}$	$\lambda_{0,1}, \mu\text{m}$	A, mm	FWHM, grad		$D^*, \text{cmHz}^{1/2}/\text{W}$
PD19	1.9	1.8÷2.05	Ø 3	15	Sr, TO39, TO8	1.6E11
PD21	2.1	1.8÷2.25	Ø 3	15	Sr, TO39, TO8	1.6E11
PD27	2.7	2.5÷3.1	Ø 3	15	Sr, TO39, TO8	7E10
PD29	2.9	2.65÷3.3	Ø 3	15	Sr, TO39, TO8	4E10
PD34	3.35	2.8÷3.75	Ø 3	15	Sr, TO39, TO8	6E10
PD38	3.2÷3.7	2.6÷4.25	Ø 3	15	Sr, TO39, TO8	3E10
PD42NB	3.9÷4.0	3.15÷4.75	Ø 3	15	Sr, TO39, TO8	2E10
PD42WB	4.1÷4.2	2.75÷4.6	Ø 3	15	Sr, TO39, TO8	1.5E10
PD27FS	2.75	≤1÷3.2	0.35×0.35	140	TO18, TO39	0.5E10
PD27FSmil	2.75	≤1÷3.2	Ø 1	60	TO18, TO39	1E10
PD33FS	3.3	1.5÷3.8	0.35×0.35	140	TO18, TO39	0.6E10
PD33FSmil	3.3	1.5÷3.8	Ø 1	60	TO18, TO39	1.5E10
PD42FS	4.15	2.5÷4.65	0.35×0.35	140	TO18, TO39	1.5E9
PD42FSmil	4.15	2.5÷4.65	Ø 1	60	TO18, TO39	3E9
PD52FS	5.2	≤2÷5.8	0.35×0.35	140	TO18, TO39	1E8
PD52FSmil	5.2	≤2÷5.8	Ø 1	60	TO18, TO39	2E8

Back side illuminated Optically Immersed Photodiodes



Front side illuminated Photodiodes



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Back side illuminated Optically Immersed Photodiodes

Optically Immersed 1.9 μm Photodiode PD19Su, PD19Sr.....	3
TE cooled Optically Immersed 1.9 μm Photodiode PD19TO8TEC.....	3
Optically Immersed 2.1 μm Photodiode PD21Su, PD21Sr.....	5
TE cooled Optically Immersed 2.1 μm Photodiode PD21TO8TEC.....	5
Optically Immersed 2.7 μm Photodiode PD27Su, PD27Sr.....	7
TE cooled Optically Immersed 2.7 μm Photodiode PD27TO8TEC.....	7
Optically Immersed 2.9 μm Photodiode PD29Su, PD29Sr.....	9
TE cooled Optically Immersed 2.9 μm Photodiode PD29TO8TEC	9
Optically Immersed 3.4 μm Photodiode PD34Su, PD34Sr.....	11
TE cooled Optically Immersed 3.4 μm Photodiode PD34TO8TEC.....	11
Optically Immersed 3.8 μm Photodiode PD38Su, PD38Sr	13
TE cooled Optically Immersed 3.8 μm Photodiode PD38TO8TEC	13
Optically Immersed 4.2 μm Photodiode PD42Su, PD42Sr.....	15
TE cooled Optically Immersed 4.2 μm Photodiode PD42TO8TEC.....	15
 Thermoelectric cooling module TO8TEC datasheet	17

Front side illuminated Photodiodes

Uncooled 2.7 μm FSI Photodiode PD27FS.....	18
TE cooled 2.7 μm FSI Photodiode PD27FS TO39TEC	18
Uncooled 2.7 μm FSI Photodiode with microimmersion lens PD27FSmIL.....	18
TE cooled 2.7 μm FSI Photodiode with microimmersion lens PD27FSmIL TO39TEC	18
Uncooled 3.3 μm FSI Photodiode PD33FS	20
TE cooled 3.3 μm FSI Photodiode PD33FS TO39TEC	20
Uncooled 3.3 μm FSI Photodiode with microimmersion lens PD33FSmIL	20
TE cooled 3.3 μm FSI Photodiode with microimmersion lens PD33FSmIL TO39TEC.....	20
Uncooled 4.1 μm FSI Photodiode PD41FS	22
TE cooled 4.1 μm FSI Photodiode PD41FS TO39TEC	22
Uncooled 4.1 μm FSI Photodiode with microimmersion lens PD41FSmIL	22
TE cooled 4.1 μm FSI Photodiode with microimmersion lens PD41FSmIL TO39TEC.....	22
Uncooled 5.2 μm FSI Photodiode PD52FS	24
TE cooled 5.2 μm FSI Photodiode PD52FS TO39TEC	24
Uncooled 5.2 μm FSI Photodiode with microimmersion lens PD52FSmIL	24
TE cooled 5.2 μm FSI Photodiode with microimmersion lens PD52FSmIL TO39TEC.....	24
 Thermoelectric cooling module TO39TEC datasheet.....	26

Infrared detection modules PDMxx	27
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Amplifier for MW IR photodiodes Ampxx.....	27
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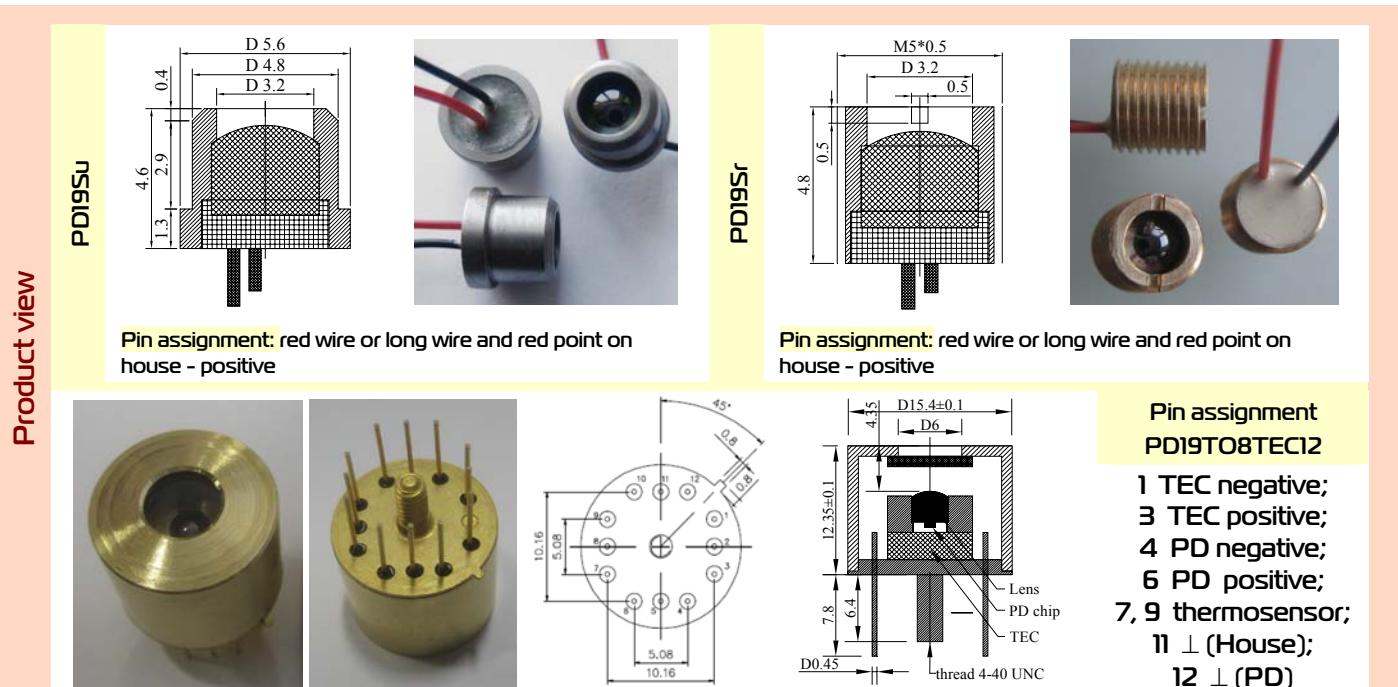


Optically Immersed 1.9 μm Photodiode PD19Su, PD19Sr

TE cooled Optically Immersed 1.9 μm Photodiode PD19TO8TEC

Peak wavelength	λ_{\max}	μm	1.9	@22 °C
Current sensitivity at λ_{\max}	$S_i(\lambda_{\max})$	A/W	≥ 0.6	
Shunt Resistance	R_s	kOhm	≥ 20	
Detectivity	$D^*_{\lambda_{\max}}$	$\text{cmHz}^{1/2}\text{W}^{-1}$	$\geq 1.6 \times 10^{11}$	
Voltage sensitivity	S_u	V/W	$\geq 12\,000$	
Switching time	τ	ns	≤ 20	¹

Code	Sensitive area, mm	Weight, g	Optical components	Field of view, deg.	Optical axis deviation, deg.	Detectivity deviation in lot, %	Operation conditions, °C	Lifetime, hrs
PD19Su			Si lens				-60÷+85 ²	
PD19Sr	$\varnothing 3.2$	~0.4	Si lens					
PD19TO8TEC		~10	Si lens and output sapphire window D=6mm	~15	≤ 5	± 25	-60÷+85 ³	>80 000



Features

- Original growth of narrow gap A3B5 semiconductor alloys onto n⁻-GaSb substrate;
- Flip-chip design of PDs;
- Optical coupling through the use of chalcogenide glasses and Si lenses with antireflection coating
- Ambient and high temperature operation;
- No bias required;
- Operation from DC to VHF;
- Highest long term stability;
- High value of shunt resistance;

Photodiode could be equipped with preamplifier that is designed for conversion of PD photocurrent into a convenient output voltage and is adjusted for the particular PD taking into account the R_o value and frequency range. Other packages are available upon request. Angle of view is small and thus we recommend adjusting PD position regarding to the emission system before final evaluation/use of the devices. Data are valid for PD thermostabilized at 22°C. Heatsink is essential for TEC operation!

¹ - according to estimation
² - devices have passed through 15 thermo cycles : (20°C, 8 hrs) -transition period of 30 min - (+125°C, 8 hrs) without changes in specifications. Valid for devices produced since 01.2013
³ - devices have passed through 15 thermo cycles : (-60°C, 30 min) - transition period of 30 min -(+85°C, 30 min) without changes in specifications. Valid for devices produced since 01.2013

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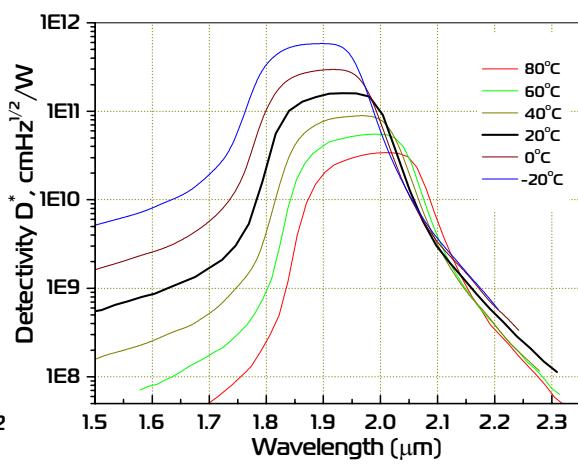
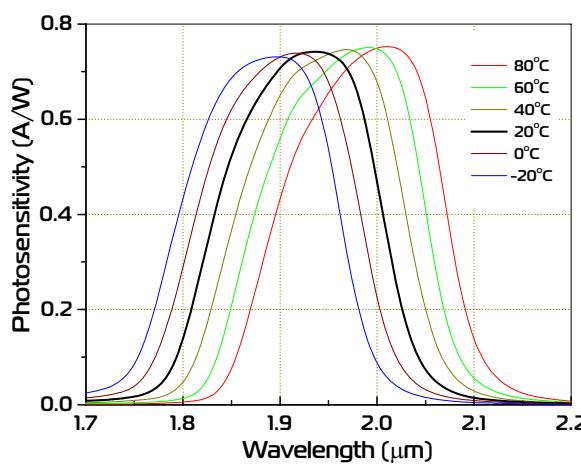


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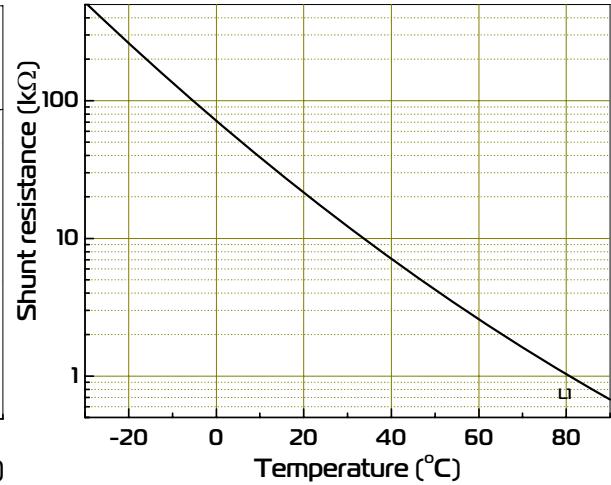
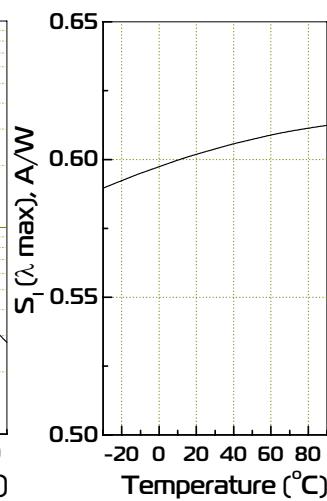
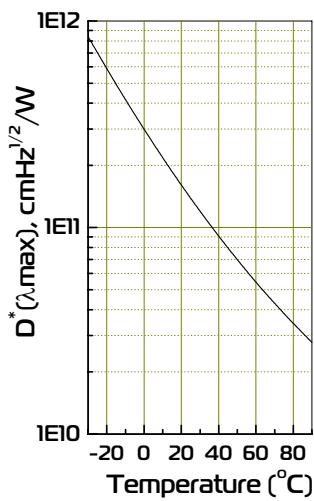
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Spectral response



Detectivity, current sensitivity at λ_{\max} and shunt resistance vs. temperature



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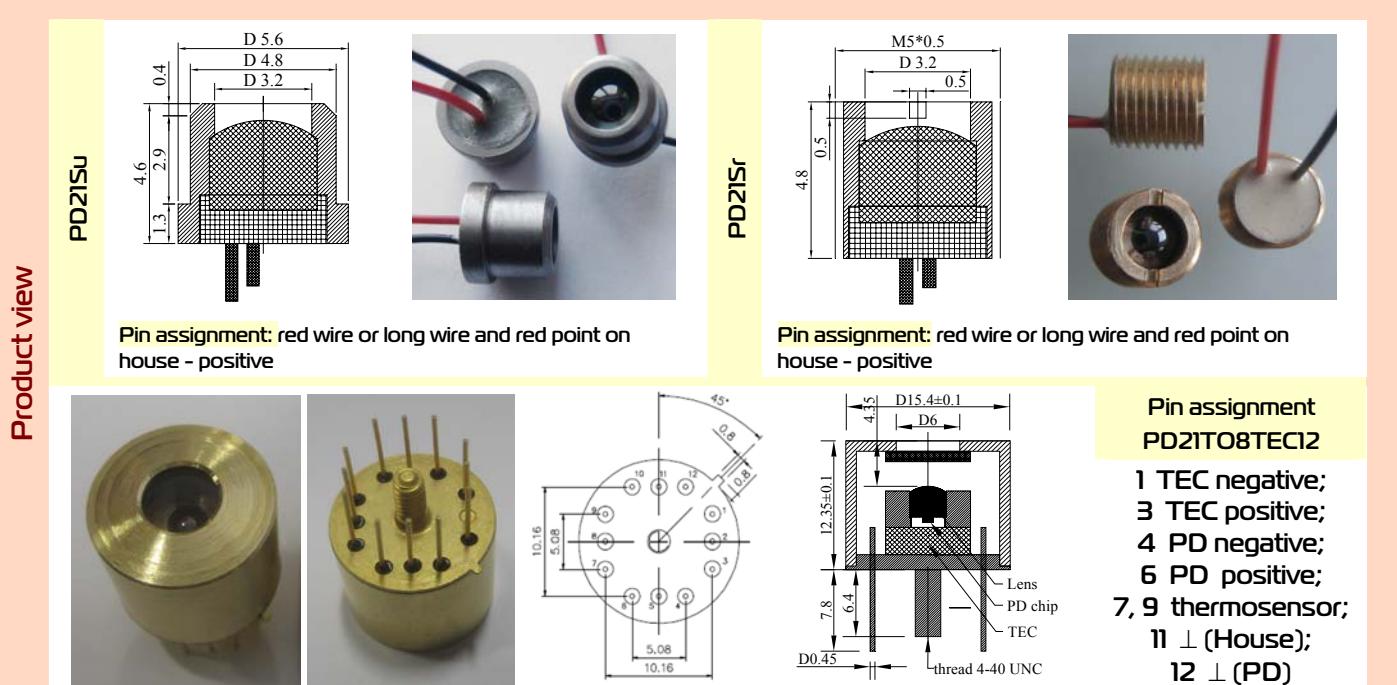
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Optically Immersed 2.1 μm Photodiode PD21Su, PD21Sr

TE cooled Optically Immersed 2.1 μm Photodiode PD21TO8TEC

Peak wavelength	λ_{\max}	μm	2.0÷2.1	@22 °C
Current sensitivity at λ_{\max}	$S_i(\lambda_{\max})$	A/W	≥0.6	
Shunt Resistance	R_s	kOhm	≥20	
Detectivity	$D^*_{\lambda_{\max}}$	$\text{cmHz}^{1/2}\text{W}^{-1}$	≥1.6×10¹¹	
Voltage sensitivity	S_u	V/W	≥12 000	
Switching time	τ	ns	≤20	¹

Code	Sensitive area, mm	Weight, g	Optical components	Field of view, deg.	Optical axis deviation, deg.	Detectivity deviation in lot, %	Operation conditions, °C	Lifetime, hrs
PD21Su							-60÷+85 ²	
PD21Sr	$\varnothing 3.2$	~0.4	Si lens					
PD21TO8TEC		~10	Si lens and output sapphire window D=6mm	~15	≤5	±25	-60÷+85 ³	>80 000



Features

- Original growth of narrow gap A3B5 semiconductor alloys onto n⁻-GaSb substrate;
- Flip-chip design of PDs;
- Optical coupling through the use of chalcogenide glasses and Si lenses with antireflection coating
- Ambient and high temperature operation;
- No bias required;
- Operation from DC to VHF;
- Highest long term stability;
- High value of shunt resistance;

Photodiode could be equipped with preamplifier that is designed for conversion of PD photocurrent into a convenient output voltage and is adjusted for the particular PD taking into account the R_o value and frequency range. Other packages are available upon request. Angle of view is small and thus we recommend adjusting PD position regarding to the emission system before final evaluation/use of the devices. Data are valid for PD thermostabilized at 22°C. Heatsink is essential for TEC operation!

¹ - according to estimation
² - devices have passed through 15 thermo cycles : (20°C, 8 hrs) -transition period of 30 min - (+125°C, 8 hrs) without changes in specifications. Valid for devices produced since 01.2013
³ - devices have passed through 15 thermo cycles : (-60°C, 30 min) - transition period of 30 min -(+85°C, 30 min) without changes in specifications. Valid for devices produced since 01.2013

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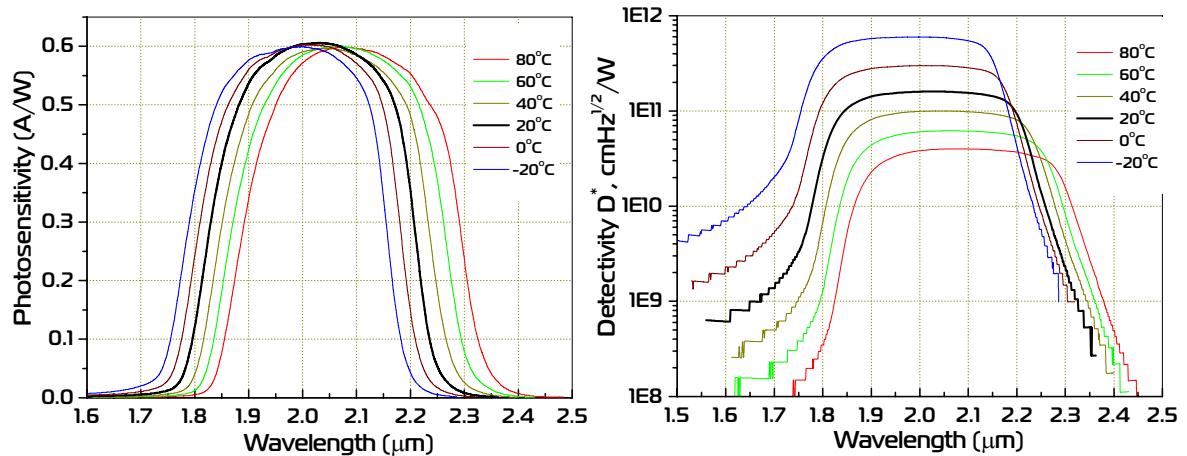


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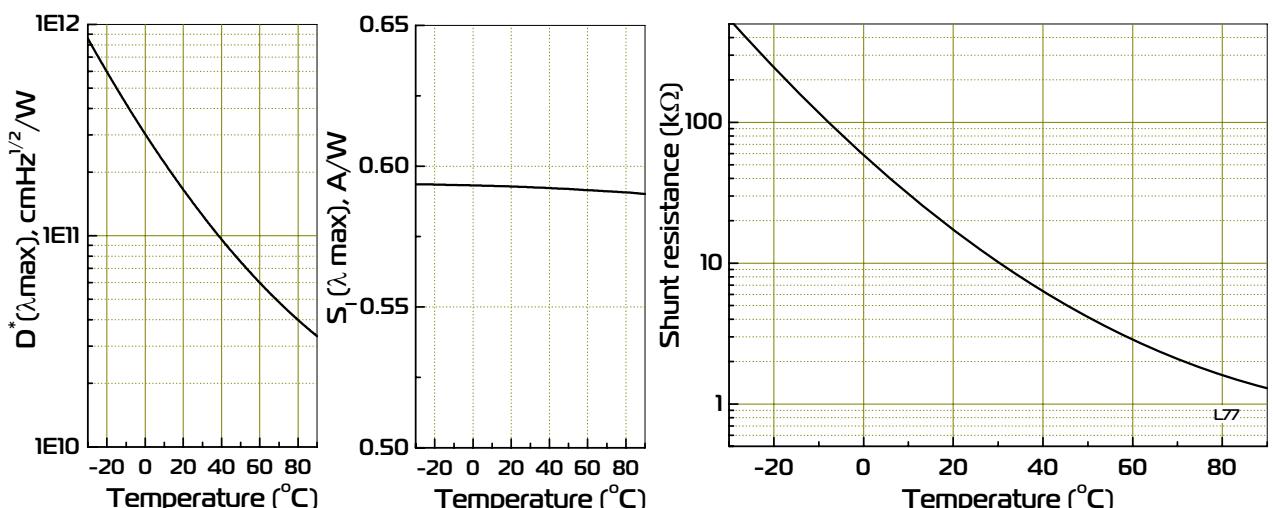
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Spectral response



Detectivity, current sensitivity at λ_{max} and shunt resistance vs. temperature



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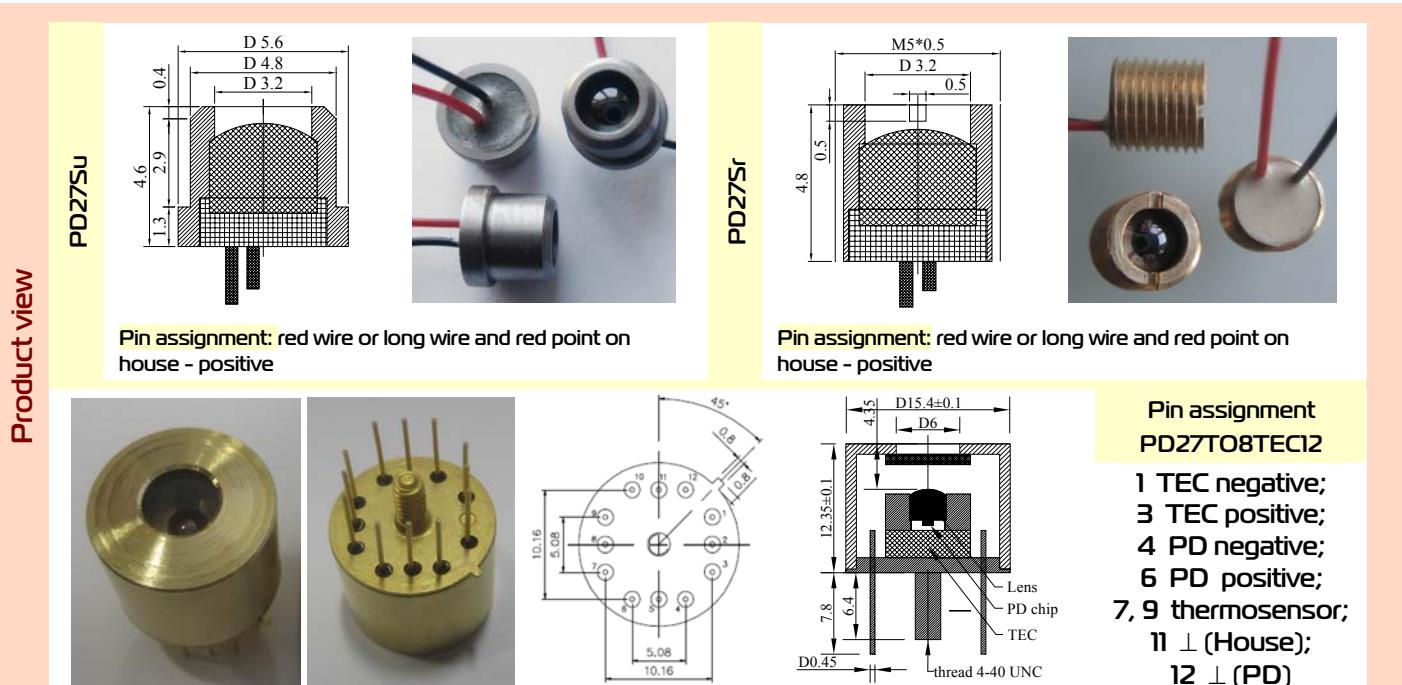
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Optically Immersed 2.7 μm Photodiode PD27Su, PD27Sr

TE cooled Optically Immersed 2.7 μm Photodiode PD27TO8TEC

Peak wavelength	λ_{\max}	μm	2.73±0.05	¹	@22 °C
Current sensitivity	S_i	A/W	≥0.5		
Shunt Resistance	R_s	Ohm	≥2500		
Detectivity	$D^*_{\lambda_{\max}}$	$\text{cmHz}^{1/2}\text{W}^{-1}$	≥7×10 ¹⁰		
Voltage sensitivity	S_u	V/W	≥1250		
Switching time	τ	ns	≤20	²	

Code	Sensitive area, mm	Weight, g	Optical components	Field of view, deg.	Optical axis deviation, deg.	Detectivity deviation in lot, %	Operation conditions, °C	Lifetime, hrs
PD27Su							-60÷+85 ³	
PD27Sr	$\varnothing 3.2$	~0.4	Si lens					>80 000
PD27								
TO8TEC		~10	Si lens and output sapphire window D=6mm	~15	≤5	±25	-60÷+85 ⁴	



Features

- Original growth of narrow gap A3B5 semiconductor alloys onto n⁻-InAs substrate;
- Flip-chip design of PDs;
- Optical coupling through the use of chalcogenide glasses and Si lenses with antireflection coating
- Ambient and high temperature operation;
- No bias required;
- Operation from DC to VHF;
- Highest long term stability;
- High value of shunt resistance;

Photodiode could be equipped with preamplifier that is designed for conversion of PD photocurrent into a convenient output voltage and is adjusted for the particular PD taking into account the R_o value and frequency range. Other packages are available upon request. Angle of view is small and thus we recommend adjusting PD position regarding to the emission system before final evaluation/use of the devices. Data are valid for PD thermostabilized at 22°C. Heatsink is essential for TEC operation!

Notes

- ¹ - process 296
² - according to estimation
³ - devices have passed through 15 thermo cycles : (20°C, 8 hrs) -transition period of 30 min - (+125°C, 8 hrs) without changes in specifications. Valid for devices produced since 01.2013
⁴ - devices have passed through 15 thermo cycles : (-60°C, 30 min) - transition period of 30 min -(+85°C, 30 min) without changes in specifications. Valid for devices produced since 01.2013
⁵ - according to accelerated degradation stress for LEDs

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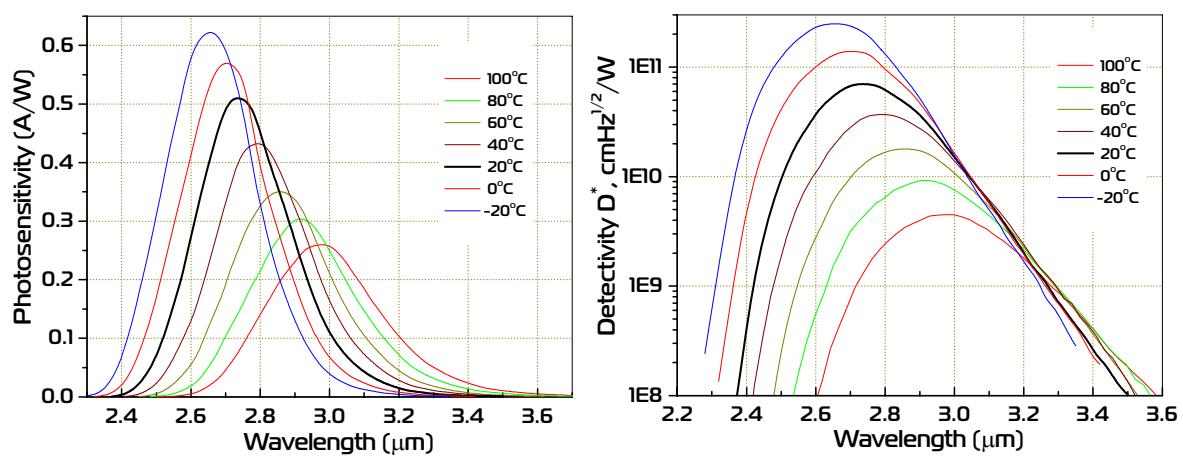


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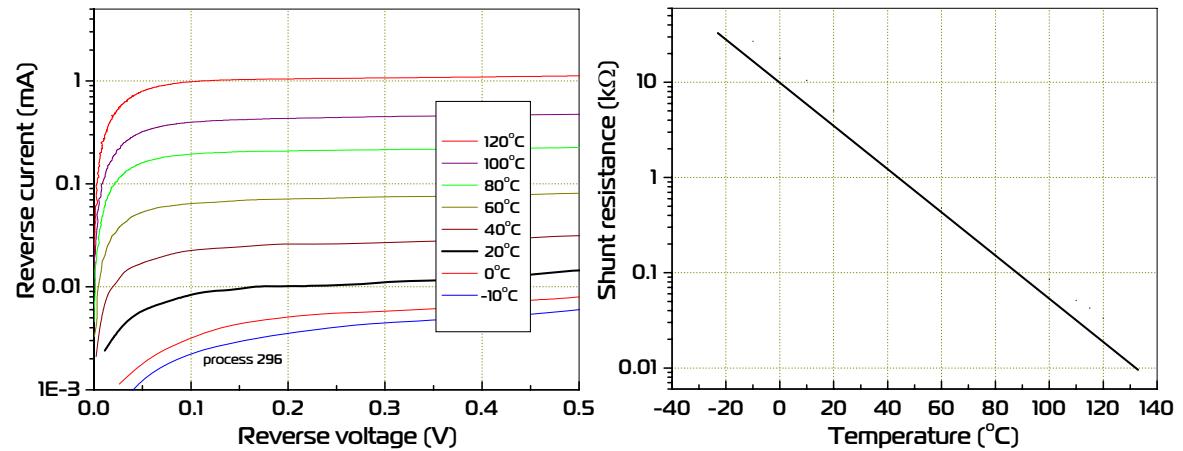
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Spectral response



Dark current vs. reverse voltage, shunt resistance vs. temperature



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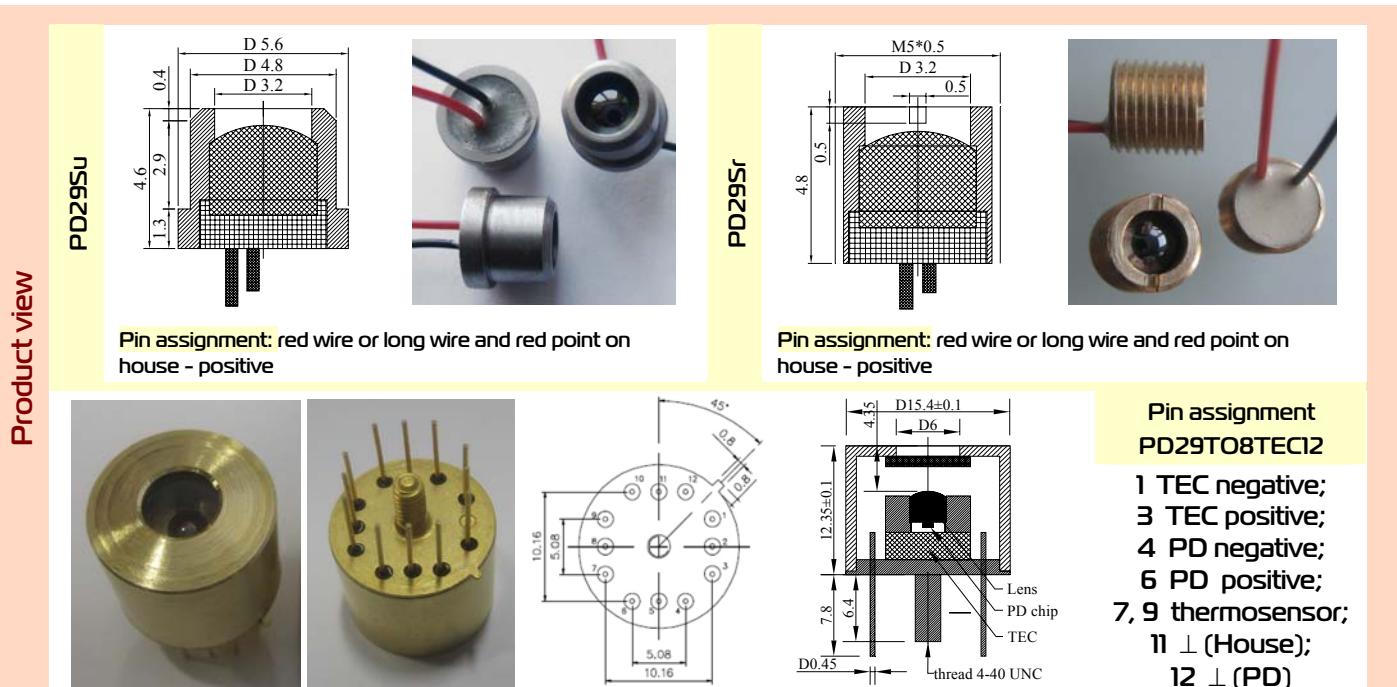
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Optically Immersed 2.9 μm Photodiode PD29Su, PD29Sr

TE cooled Optically Immersed 2.9 μm Photodiode PD29TO8TEC

Peak wavelength	λ_{\max}	μm	2.93 ± 0.05	¹	@22 °C
Current sensitivity	S_i	A/W	≥ 0.5		
Shunt Resistance	R_s	Ohm	≥ 1500		
Detectivity	$D^*_{\lambda_{\max}}$	$\text{cmHz}^{1/2}\text{W}^{-1}$	$\geq 4 \times 10^{10}$		
Voltage sensitivity	S_u	V/W	≥ 750		
Switching time	τ	ns	≤ 20	²	

Code	Sensitive area, mm	Weight, g	Optical components	Field of view, deg.	Optical axis deviation, deg.	Detectivity deviation in lot, %	Operation conditions, °C	Lifetime, hrs
PD29Su			Si lens				-60÷+85 ³	
PD29Sr	$\varnothing 3.2$	~0.4	Si lens					>80 000
PD29 TO8TEC		~10	Si lens and output sapphire window D=6mm	~15	≤ 5	± 25	-60÷+85 ⁴	



Features

- Original growth of narrow gap A3B5 semiconductor alloys onto n⁻-InAs substrate;
- Flip-chip design of PDs;
- Optical coupling through the use of chalcogenide glasses and Si lenses with antireflection coating
- Ambient and high temperature operation;
- No bias required;
- Operation from DC to VHF;
- Highest long term stability;
- High value of shunt resistance;

Photodiode could be equipped with preamplifier that is designed for conversion of PD photocurrent into a convenient output voltage and is adjusted for the particular PD taking into account the R_o value and frequency range. Other packages are available upon request. Angle of view is small and thus we recommend adjusting PD position regarding to the emission system before final evaluation/use of the devices. Data are valid for PD thermostabilized at 22°C. Heatsink is essential for TEC operation!

Notes

¹ - process 6189

² - according to estimation

³ - devices have passed through 15 thermo cycles : (20°C, 8 hrs) -transition period of 30 min - (+125°C, 8 hrs) without changes in specifications. Valid for devices produced since 01.2013

⁴ - devices have passed through 15 thermo cycles : (-60°C, 30 min) - transition period of 30 min - (+85°C, 30 min) without changes in specifications. Valid for devices produced since 01.2013

⁵ - according to accelerated degradation stress for LEDs

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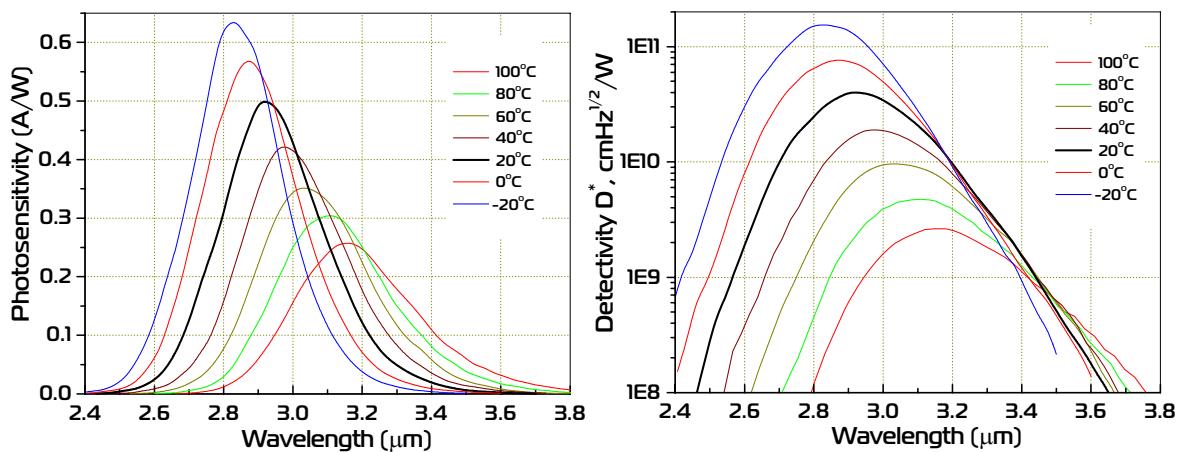


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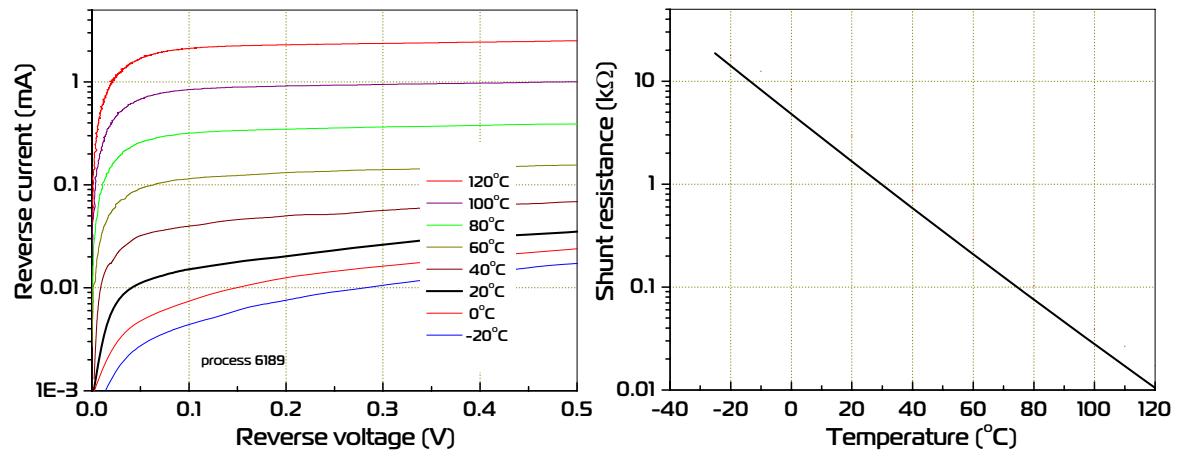
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Spectral response



Dark current vs. reverse voltage, shunt resistance vs. temperature



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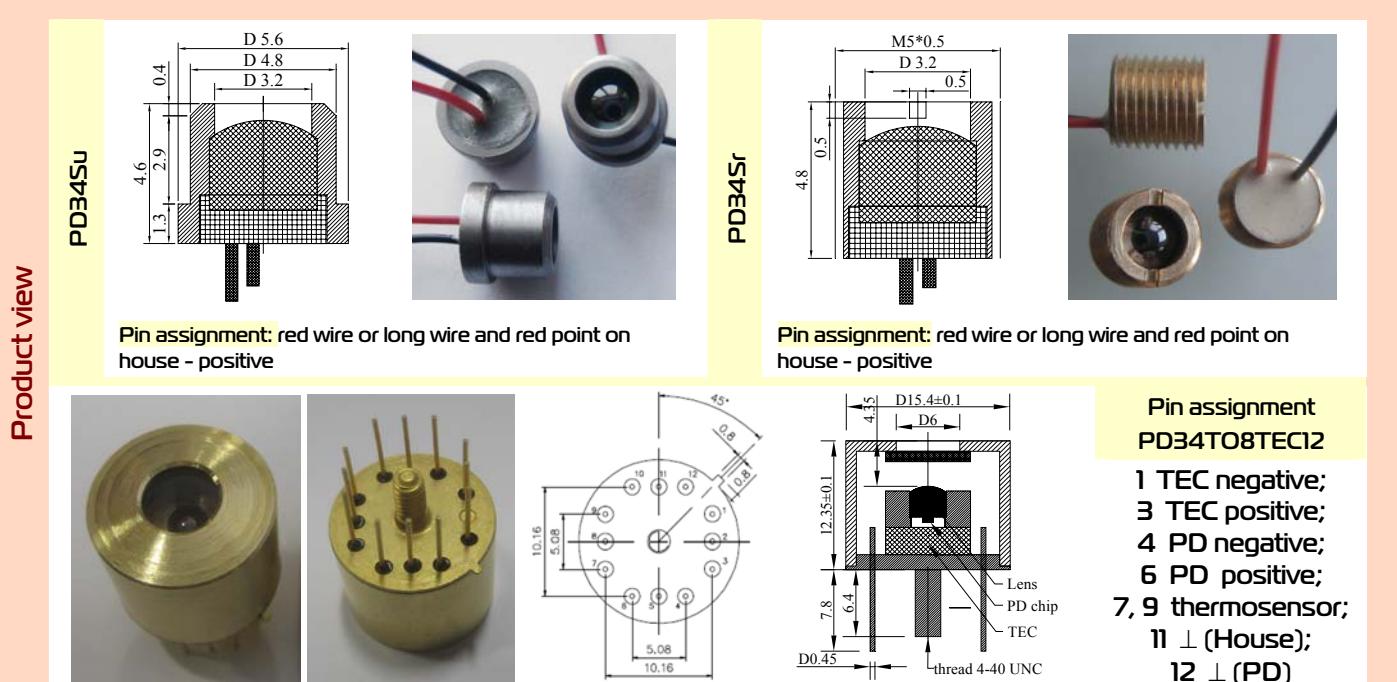
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Optically Immersed 3.4 μm Photodiode PD34Su, PD34Sr

TE cooled Optically Immersed 3.4 μm Photodiode PD34TO8TEC

Peak wavelength	λ_{\max}	μm	3.35 ± 0.05	@22 °C
Current sensitivity	S_i	A/W	≥ 1.0	
Shunt Resistance	R_s	Ohm	≥ 1000	
Detectivity	$D^*_{\lambda_{\max}}$	$\text{cmHz}^{1/2}\text{W}^{-1}$	$\geq 6 \times 10^{10}$	
Voltage sensitivity	S_u	V/W	≥ 1000	
Switching time	τ	ns	≤ 20	¹

Code	Sensitive area, mm	Weight, g	Optical components	Field of view, deg.	Optical axis deviation, deg.	Detectivity deviation in lot, %	Operation conditions, °C	Lifetime, hrs
PD34Su	$\varnothing 3.2$	~0.4	Si lens	~15	≤ 5	± 25	-60÷+85 ²	>80 000
PD34Sr	$\varnothing 3.2$	~10	Si lens and output sapphire window D=6mm				-60÷+85 ³	
PD34 TO8TEC								



Features

- Original growth of narrow gap AlSb semiconductor alloys onto n⁻-InAs substrate;
- Flip-chip design of PDs;
- Optical coupling through the use of chalcogenide glasses and Si lenses with antireflection coating
- Ambient and high temperature operation;
- No bias required;
- Operation from DC to VHF;
- Highest long term stability;
- High value of shunt resistance;

Photodiode could be equipped with preamplifier that is designed for conversion of PD photocurrent into a convenient output voltage and is adjusted for the particular PD taking into account the Ro value and frequency range. Other packages are available upon request. Angle of view is small and thus we recommend adjusting PD position regarding to the emission system before final evaluation/use of the devices. Data are valid for PD thermostabilized at 22°C. Heatsink is essential for TEC operation!

Notes	¹ - according to estimation ² - devices have passed through 15 thermo cycles : (20°C, 8 hrs) -transition period of 30 min - (+125°C, 8 hrs) without changes in specifications. Valid for devices produced since 01.2013 ³ - devices have passed through 15 thermo cycles : (-60°C, 30 min) - transition period of 30 min -(+85°C, 30 min) without changes in specifications. Valid for devices produced since 01.2013
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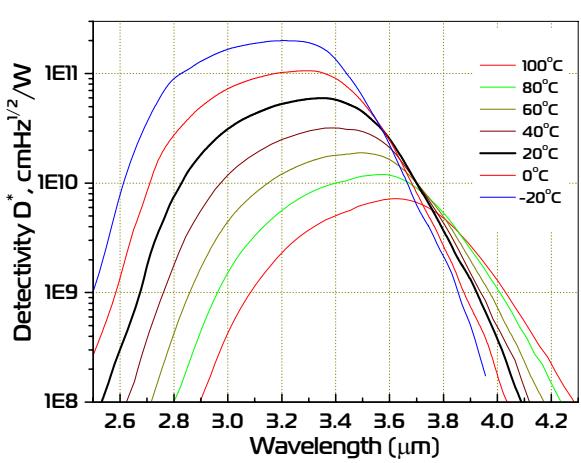
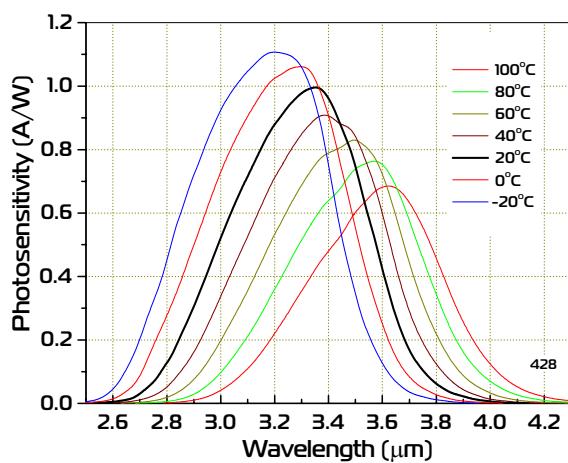


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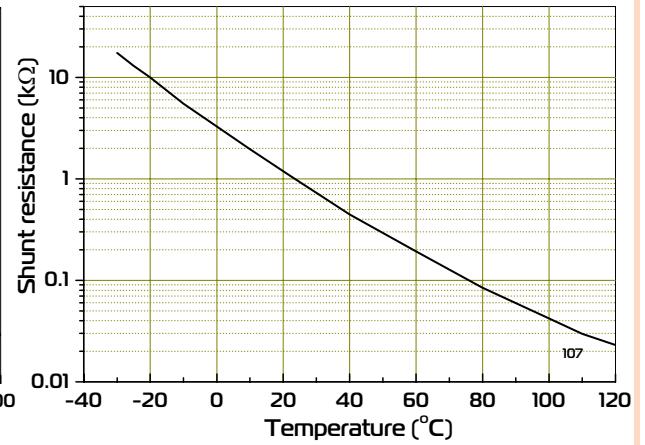
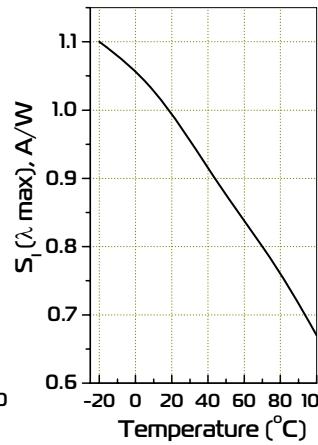
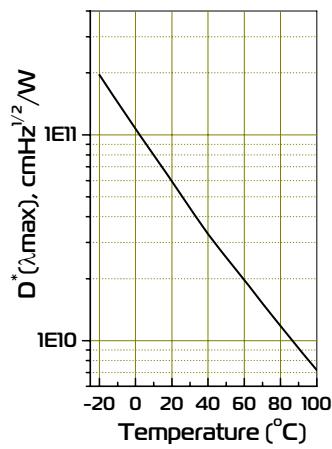
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Spectral response



Detectivity, current sensitivity at λ_{\max} and shunt resistance vs. temperature



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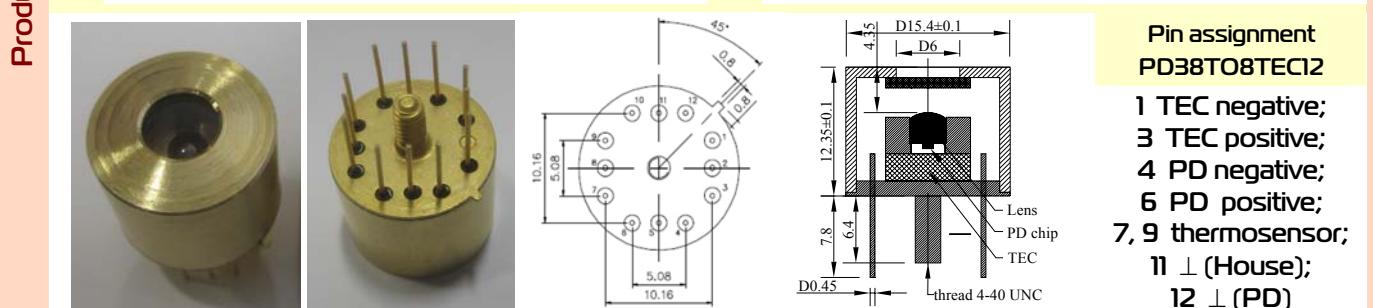
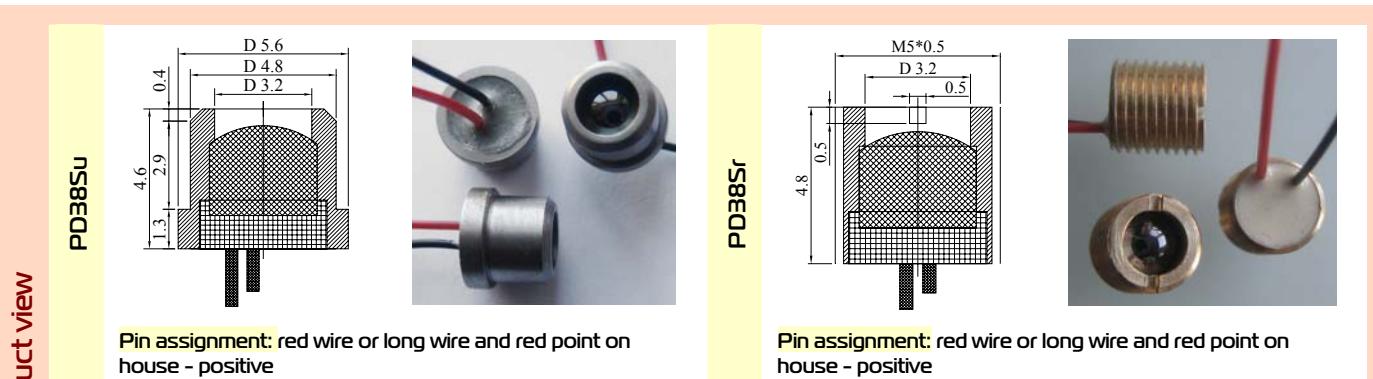
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<http://www.mirdog.spb.ru>; e-mail: bmat@iropt3.ioffe.ru

Optically Immersed 3.8 μm Photodiode PD38Su, PD38Sr

TE cooled Optically Immersed 3.8 μm Photodiode PD38TO8TEC

Peak wavelength	λ_{\max}	μm	3.2±3.7	@22 °C
Current sensitivity at λ_{\max}	$S_i(\lambda_{\max})$	A/W	≥1.0	
Current sensitivity at 3.8 μm	$S_i(3.8 \mu\text{m})$	A/W	≥0.85	
Shunt Resistance	R_o	Ohm	≥150	
Detectivity	$D^*_{\lambda_{\max}}$	$\text{cmHz}^{1/2}\text{W}^{-1}$	≥2.6×10¹⁰	
Voltage sensitivity	S_u	V/W	≥150	
Switching time	τ	ns	≤20	¹

Code	Sensitive area, mm	Weight, g	Optical components	Field of view, deg.	Optical axis deviation, deg.	Detectivity deviation in lot, %	Operation conditions, °C	Lifetime, hrs
PD38Su							-60÷+85 ²	
PD38Sr	$\varnothing 3.2$	~0.4	Si lens					>80 000
PD38 TO8TEC		~10	Si lens and output sapphire window D=6mm	~15	≤5	±25	-60÷+85 ³	



Features

- Original growth of narrow gap A3B5 semiconductor alloys onto n⁻-InAs substrate;
- Flip-chip design of PDs;
- Optical coupling through the use of chalcogenide glasses and Si lenses with antireflection coating

- Ambient and high temperature operation;
- No bias required;
- Operation from DC to VHF;
- Highest long term stability;
- High value of shunt resistance;

Photodiode could be equipped with preamplifier that is designed for conversion of PD photocurrent into a convenient output voltage and is adjusted for the particular PD taking into account the Ro value and frequency range. Other packages are available upon request. Angle of view is small and thus we recommend adjusting PD position regarding to the emission system before final evaluation/use of the devices. Data are valid for PD thermostabilized at 22°C. Heatsink is essential for TEC operation!

Notes

¹ - according to estimation

² - devices have passed through 15 thermo cycles : (20°C, 8 hrs) -transition period of 30 min - (+125°C, 8 hrs) without changes in specifications. Valid for devices produced since 01.2013

³ - devices have passed through 15 thermo cycles : (-60°C, 30 min) - transition period of 30 min -(+85°C, 30 min) without changes in specifications. Valid for devices produced since 01.2013

Product specifications are subject to change without prior notice due to improvements or other reasons. Updated 08.04.13

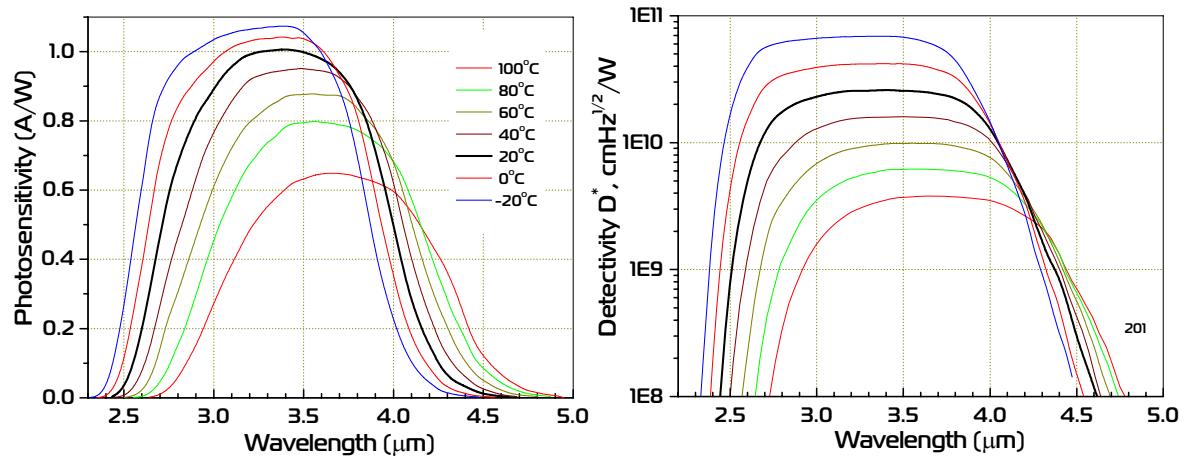


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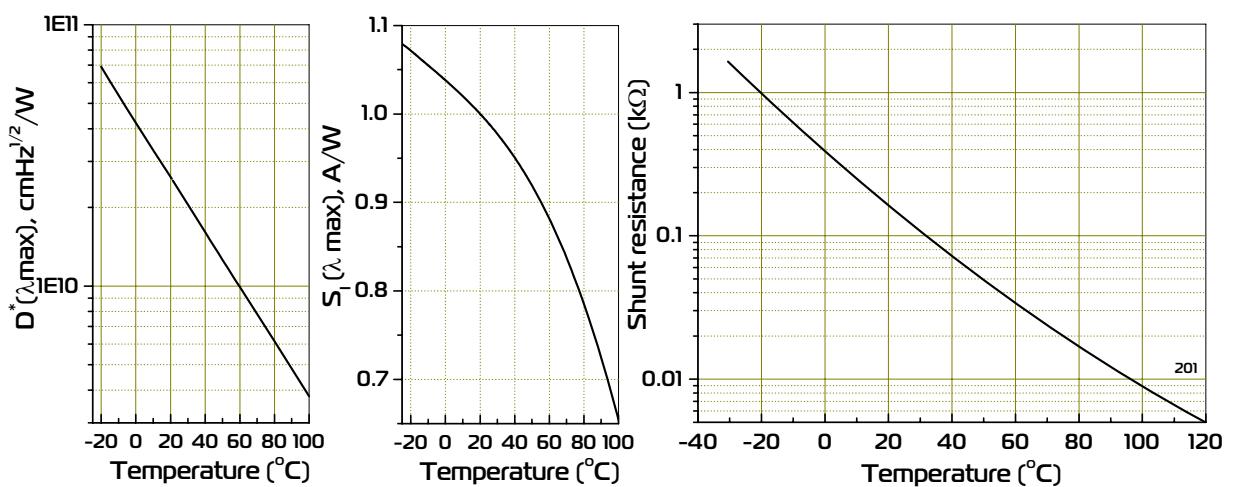
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<http://www.mirdog.spb.ru>; e-mail: brmat@iropt3.ioffe.ru

Spectral response



Detectivity, current sensitivity at λ_{\max} and shunt resistance vs. temperature



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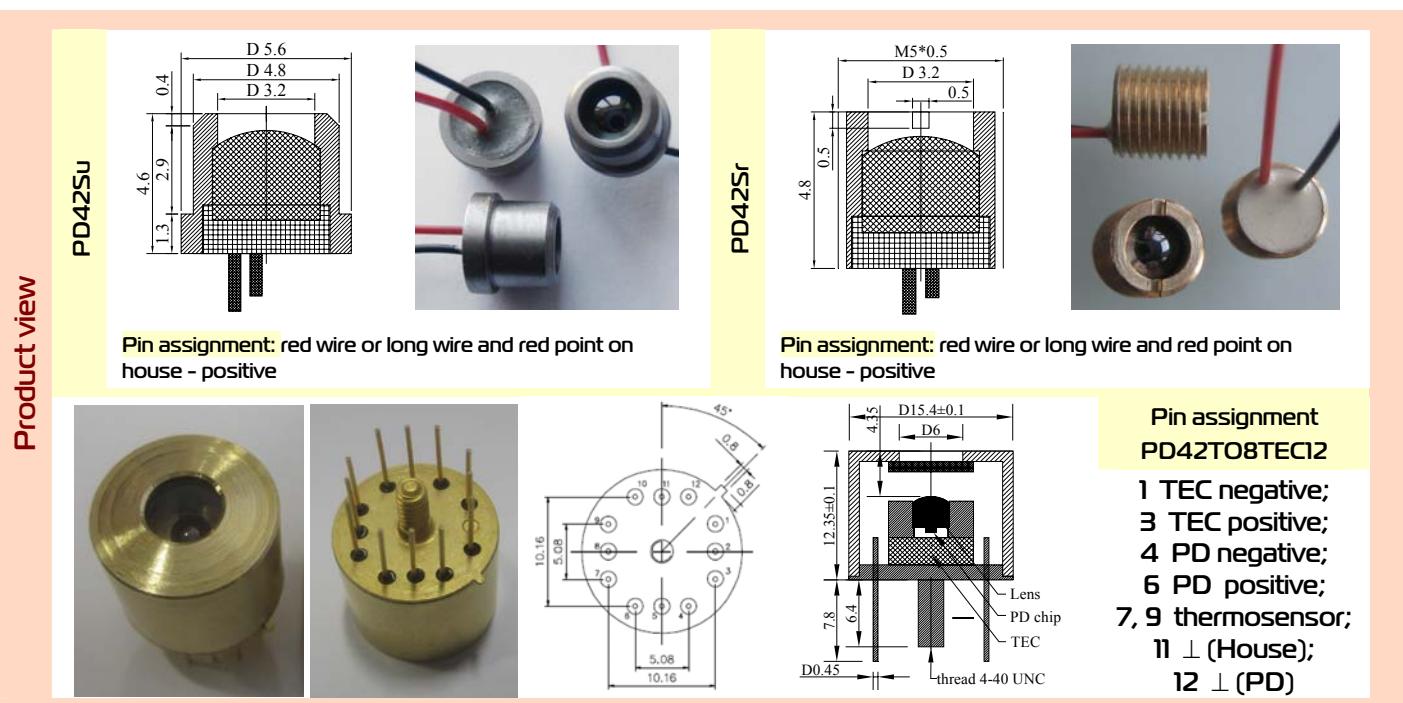
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Optically Immersed 4.2 μm Photodiode PD42Su, PD42Sr

TE cooled Optically Immersed 4.2 μm Photodiode PD42TO8TEC

			PD42Su/Sr WB	PD42Su/Sr NB
Spectral range	$\lambda_{0.1}$	μm	$2.75 \div 4.6$	$3.15 \div 4.75$
Peak wavelength	λ_{\max}	μm	$4.1 \div 4.2$	$@22^\circ\text{C}$
Current sensitivity at λ_{\max}	$S_i(\lambda_{\max})$	A/W	≥ 0.85	≥ 1.15
Current sensitivity at 4.2 μm	$S_i(4.2 \mu\text{m})$	A/W	≥ 0.8	≥ 0.9
Shunt Resistance	R_o	Ohm	≥ 70	≥ 50
Detectivity	$D^*_{\lambda_{\max}}$	$\text{cmHz}^{1/2}\text{W}^{-1}$	$\geq 1.7 \times 10^{10}$	$\geq 2.0 \times 10^{10}$
Voltage sensitivity	S_u	V/W	≥ 60	≥ 60
Switching time	τ	ns		¹ ≤ 20

Code	Sensitive area, mm	Weight, g	Optical components	Field of view, deg.	Optical axis deviation, deg.	Detectivity deviation in lot, %	Operation conditions, $^\circ\text{C}$	Lifetime, hrs
PD42Su							-60 \div +85 ²	
PD42Sr	$\varnothing 3.2$	~ 0.4	Si lens					$> 80\,000$
PD42								
TO8TEC		~ 10	Si lens and output sapphire window D=6mm	~ 15	≤ 5	± 25	-60 \div +85 ³	



Features

- Original growth of narrow gap A385 semiconductor alloys onto n⁺-InAs substrate;
- Flip-chip design of PDs;
- Optical coupling through the use of chalcogenide glasses and Si lenses with antireflection coating
- Ambient and high temperature operation;
- No bias required;
- Operation from DC to VHF;
- Highest long term stability;
- High value of shunt resistance;

Photodiode could be equipped with preamplifier that is designed for conversion of PD photocurrent into a convenient output voltage and is adjusted for the particular PD taking into account the R_o value and frequency range. Other packages are available upon request. Angle of view is small and thus we recommend adjusting PD position regarding to the emission system before final evaluation/use of the devices. Data are valid for PD thermostabilized at 22°C. Heatsink is essential for TEC operation!

Notes

¹ - according to estimation
² - devices have passed through 15 thermo cycles : (20°C, 8 hrs) - transition period of 30 min - (+125°C, 8 hrs) without changes in specifications. Valid for devices produced since 01.2013
³ - devices have passed through 15 thermo cycles : (-60°C, 30 min) - transition period of 30 min - (+85°C, 30 min) without changes in specifications. Valid for devices produced since 01.2013

Product specifications are subject to change without prior notice due to improvements or other reasons. Updated 10.04.13

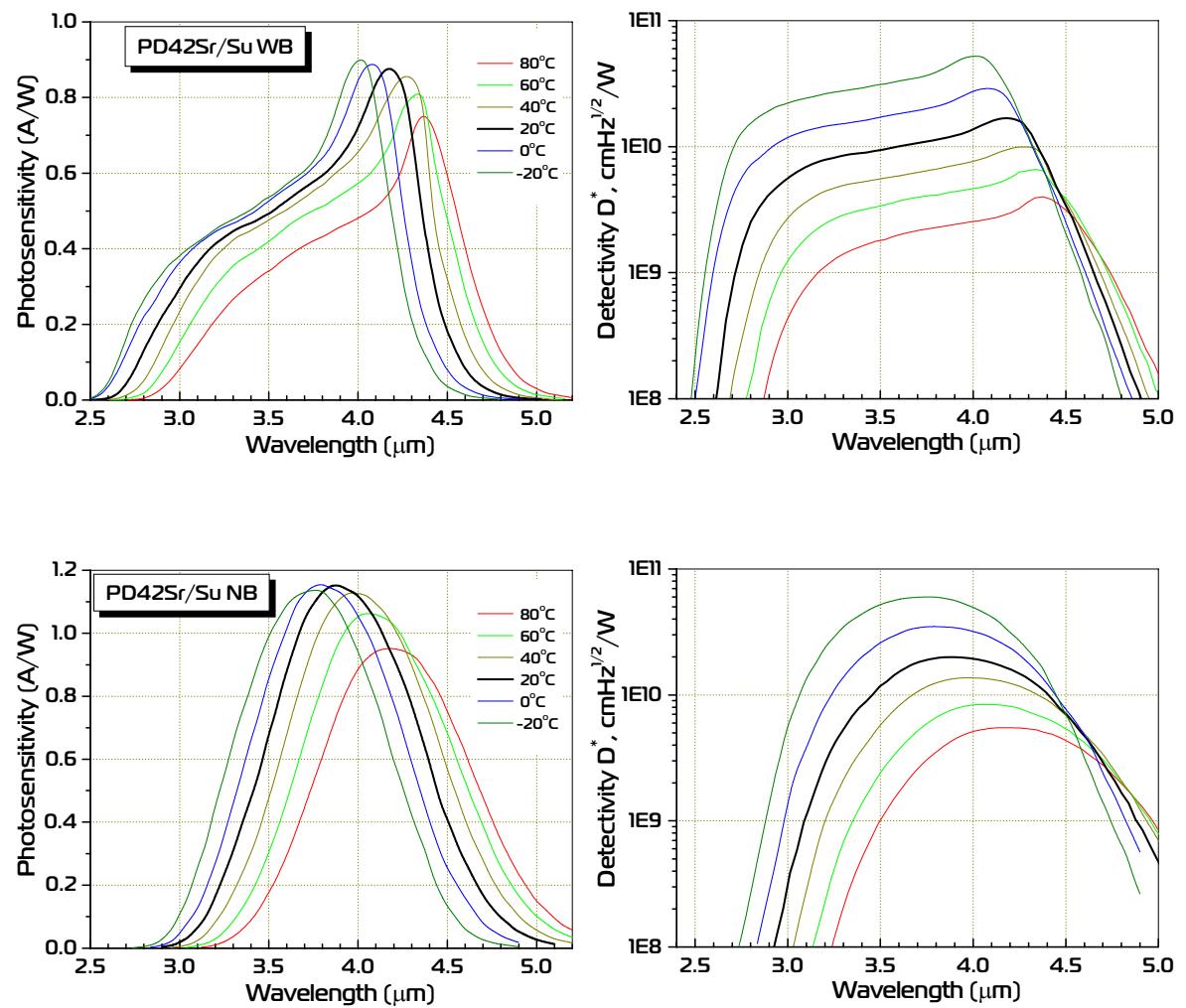


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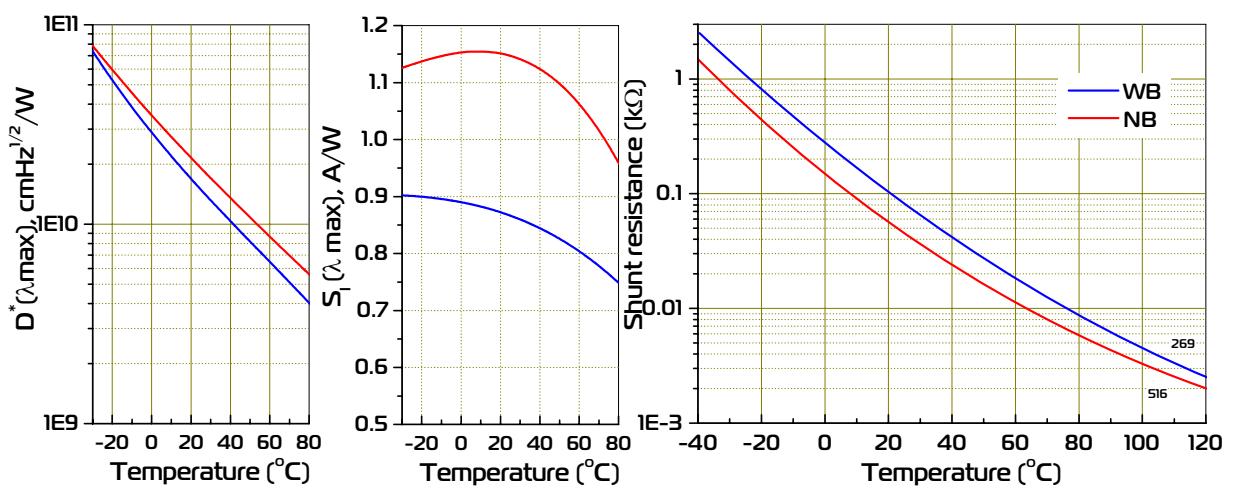
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<http://www.mirdog.spb.ru>; e-mail: bmat@iropt3.ioffe.ru

Spectral response



Detectivity, current sensitivity at λ_{\max} and shunt resistance vs. temperature



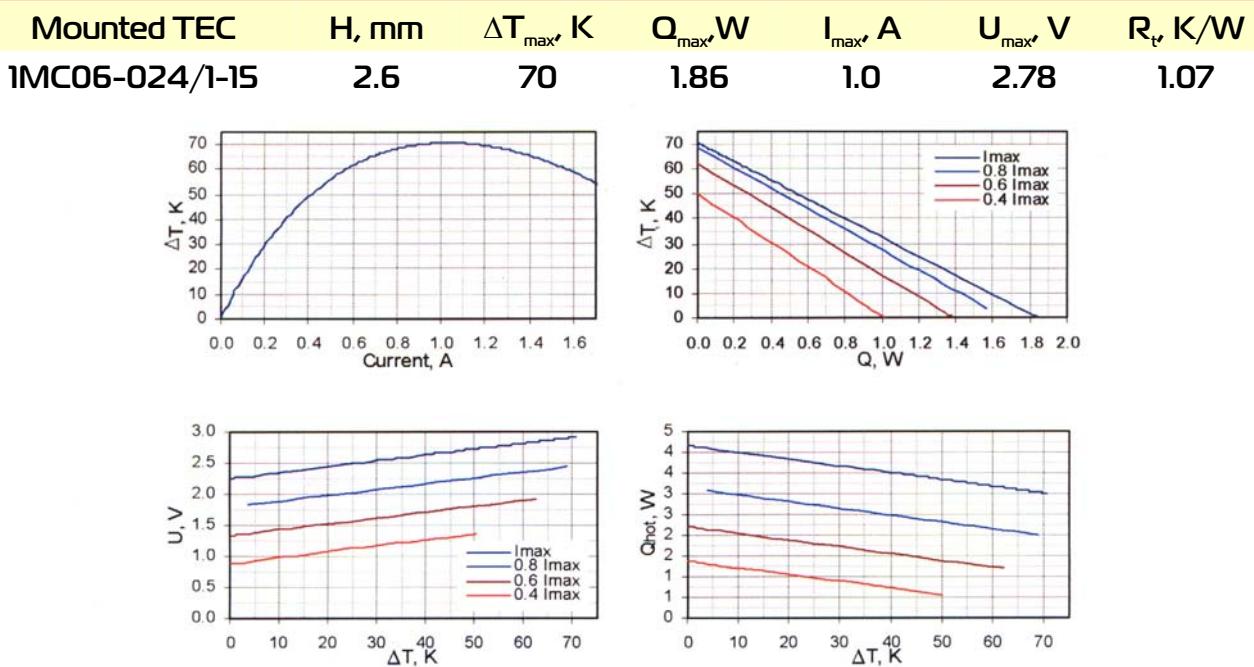
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<http://www.mirdog.spb.ru>; e-mail: brmat@iropt3.ioffe.ru

Thermoelectric cooling module TO8TEC datasheet

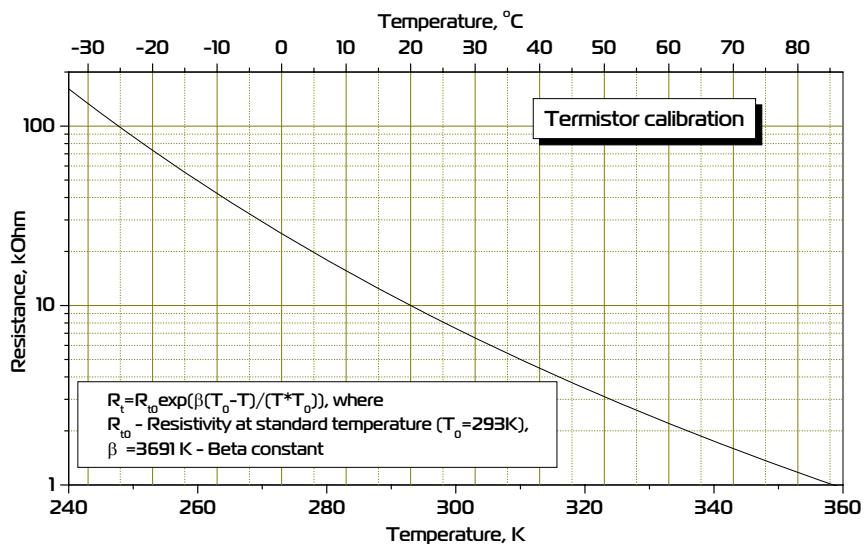
Thermoelectric cooling module datasheet



Data for $T_{hot} = 300$ K, from www.tec-microsystems.com; www.rmtltd.ru

Type TB04-103

T, °C	R, kΩ	T, °C	R, kΩ
-60	1134.5	15	12.44
-55	762.4	20	10.00
-50	521.6	25	8.09
-45	362.8	25	8.09
-40	256.3	30	6.60
-35	183.8	35	5.41
-30	133.6	40	4.47
-25	98.3	45	3.71
-20	73.3	50	3.10
-15	55.2	55	2.61
-10	42.1	60	2.20
-5	32.4	65	1.87
0	25.2	70	1.59
5	19.7	75	1.37
10	15.6	80	1.18



Possible TEC heatsink view



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Uncooled 2.7 μm FSI Photodiode PD27FS

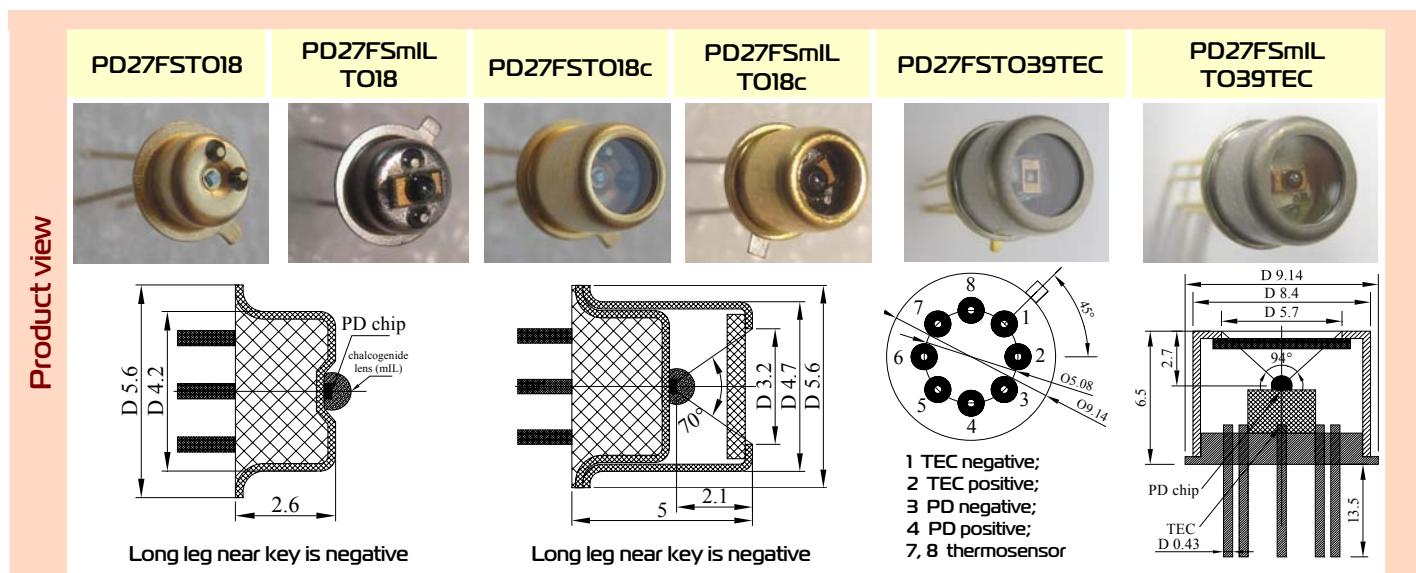
TE cooled 2.7 μm FSI Photodiode PD27FS TO39TEC

Uncooled 2.7 μm FSI Photodiode with microimmersion lens PD27FSmIL

TE cooled 2.7 μm FSI Photodiode with microimmersion lens PD27FSmIL TO39TEC

Peak wavelength	λ_{\max}	μm	2.75±0.05	@22 °C	
Immersion lens			No	mIL	
Current sensitivity	S_i	A/W	≥ 0.6 ¹⁾	≥ 0.6	
Shunt Resistance	R_s	Ohm	≥ 800	≥ 800	
Detectivity	$D^*_{\lambda_{\max}}$	$\text{cmHz}^{1/2}\text{W}^{-1}$	$\geq 0.5 \times 10^{10}$	$\geq 1.0 \times 10^{10}$	
Voltage sensitivity	S_u	V/W	≥ 500	≥ 500	
Switching time	τ	ns	≤ 20	≤ 20	

Code	Sensitive area, mm	Weight, g	Optical components	Field of view, deg.	Optical axis deviation, deg.	Detectivity deviation in lot, %	Operation conditions, °C
PD27FSTO18		~0.2	-	~140			
PD27FSTO18c	0.35×0.35	~0.3	sapphire window	~65	-	±25	-60÷+85
PD27FSTO39TEC		~1.2	sapphire window	~90			
PD27FSmILTO18		~0.2	-	~60			
PD27FSmILTO18c	~D=1	~0.3	sapphire window, chalcogenide lens	~60	≤5	±25	-60÷+60
PD27FSmILTO39TEC		~1.2	sapphire window, chalcogenide lens	~60			



Features

- Original growth of narrow gap A385 semiconductor alloys;
- Front side illuminated design of PDs;
- "Wide gap" window
- Optical coupling through the use of chalcogenide glass lenses (photodiode with microimmersion lens)
- Ambient and high temperature operation;
- No bias required;
- Operation from DC to VHF;
- Highest long term stability;
- High value of shunt resistance

Photodiode could be equipped with preamplifier that is designed for conversion of PD photocurrent into a convenient output voltage and is adjusted for the particular PD taking into account the R_o value and frequency range. Other packages are available upon request. Data are valid for PD thermostabilized at 22°C. Heatsink is essential for TEC operation!

Notes

¹ - process 285

Product specifications are subject to change without prior notice due to improvements or other reasons. Updated 21.03.13



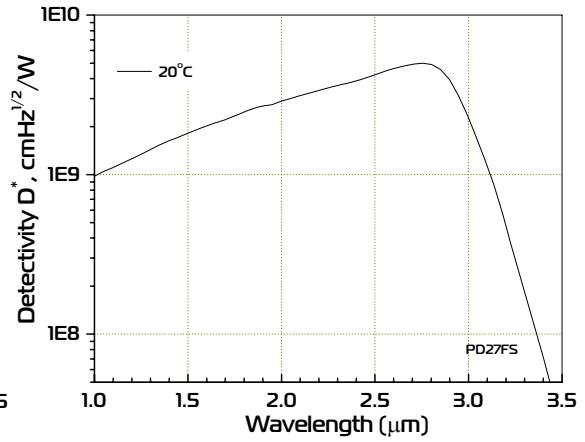
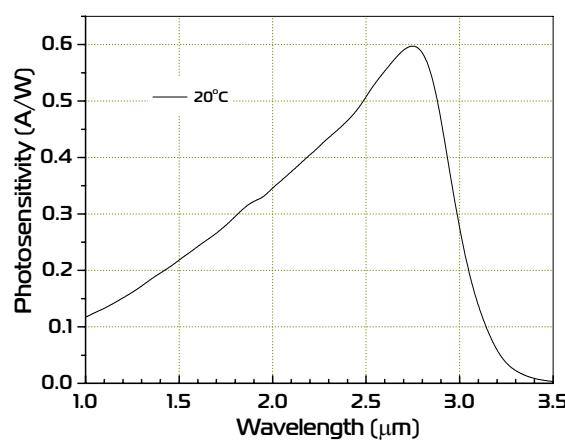
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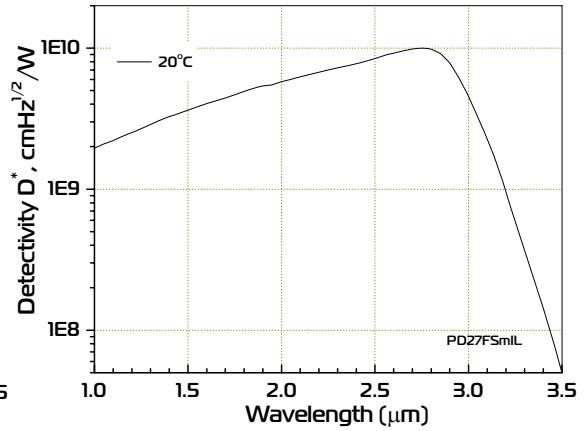
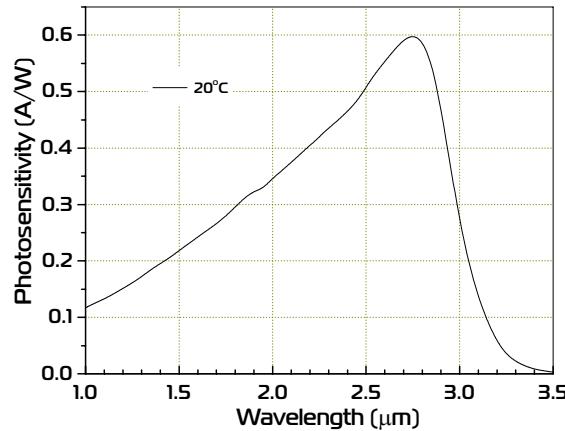
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Spectral response

PD27FS



PD27FSmIL



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Uncooled 3.3 μm FSI Photodiode PD33FS

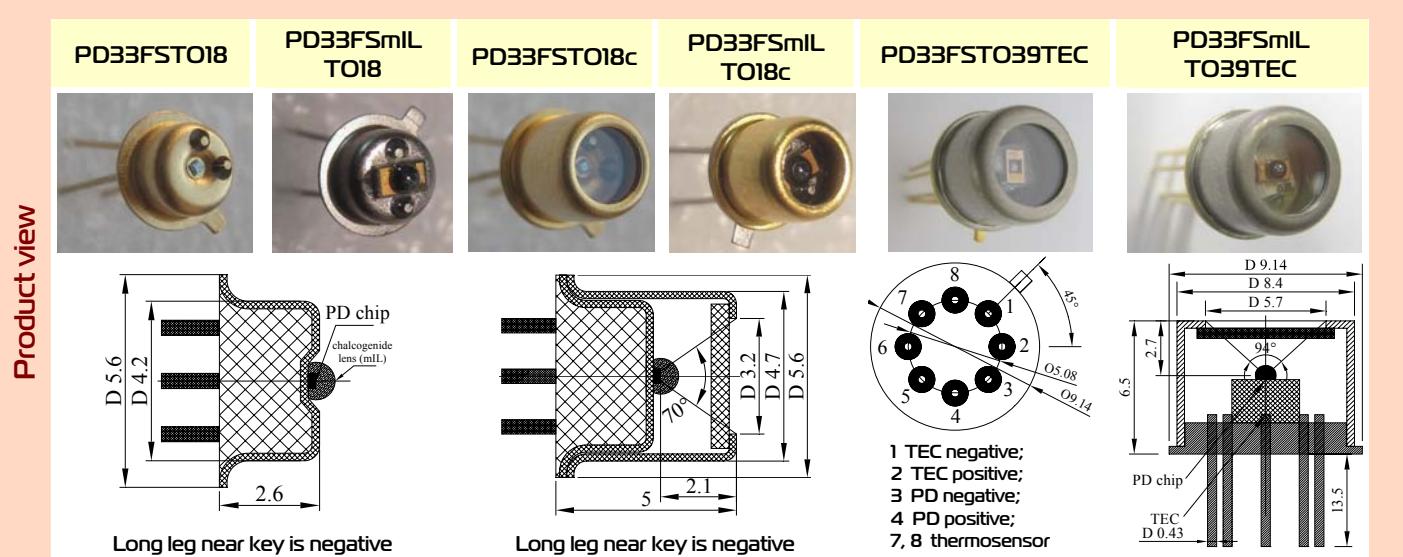
TE cooled 3.3 μm FSI Photodiode PD33FS TO39TEC

Uncooled 3.3 μm FSI Photodiode with microimmersion lens PD33FSmIL

TE cooled 3.3 μm FSI Photodiode with microimmersion lens PD33FSmIL TO39TEC

Peak wavelength	λ_{\max}	μm	3.30±0.05	@22 °C
Immersion lens		No		mIL
Current sensitivity	S_i	A/W	≥ 1 ^[1]	≥ 1
Shunt Resistance	R_o	Ohm	≥ 500	≥ 500
Detectivity	$D^*_{\lambda_{\max}}$	cmHz ^{1/2} W ⁻¹	$\geq 0.6 \times 10^{10}$	$\geq 1.5 \times 10^{10}$
Voltage sensitivity	S_u	V/W	≥ 500	≥ 500
Switching time	τ	ns	≤ 20	≤ 20

Code	Sensitive area, mm	Weight, g	Optical components	Field of view, deg.	Optical axis deviation, deg.	Detectivity deviation in lot, %	Operation conditions, °C
PD33FSTO18		~0.2	-	~140			
PD33FSTO18c	0.35×0.35	~0.3	sapphire window	~65	-	±25	-60÷+85
PD33FSTO39TEC		~1.2	sapphire window	~90			
PD33FSmILTO18		~0.2	-	~60			
PD33FSmILTO18c	~D=1	~0.3	sapphire window, chalcogenide lens	~60	≤5	±25	-60÷+60
PD33FSmILTO39TEC		~1.2	sapphire window, chalcogenide lens	~60			



Features

- Original growth of narrow gap A3B5 semiconductor alloys;
- Front side illuminated design of PDs;
- "Wide gap" window
- Optical coupling through the use of chalcogenide glass lenses (photodiode with microimmersion lens)
- Ambient and high temperature operation;
- No bias required;
- Operation from DC to VHF;
- Highest long term stability;
- High value of shunt resistance

Photodiode could be equipped with preamplifier that is designed for conversion of PD photocurrent into a convenient output voltage and is adjusted for the particular PD taking into account the R_o value and frequency range. Other packages are available upon request. Data are valid for PD thermostabilized at 22°C. Heatsink is essential for TEC operation!

Notes

¹ - process 400

Product specifications are subject to change without prior notice due to improvements or other reasons. Updated 21.03.13



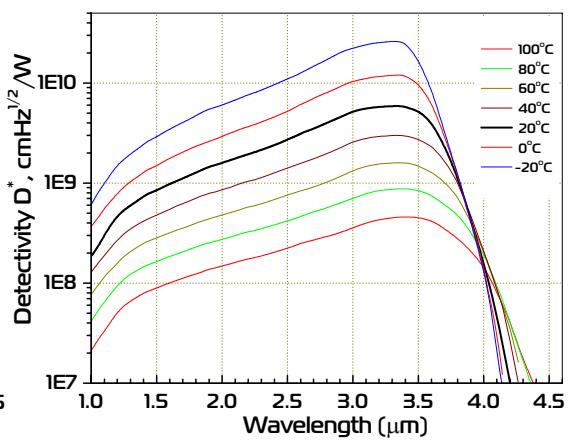
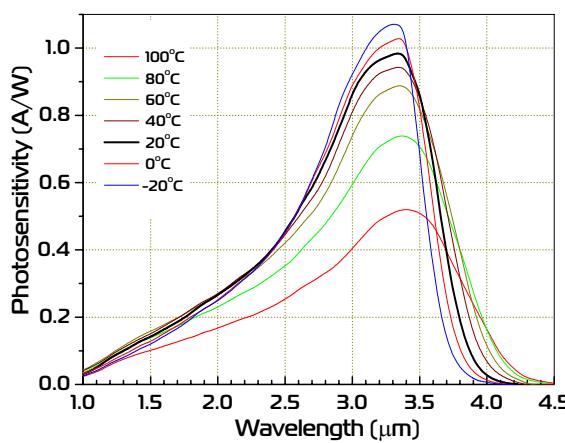
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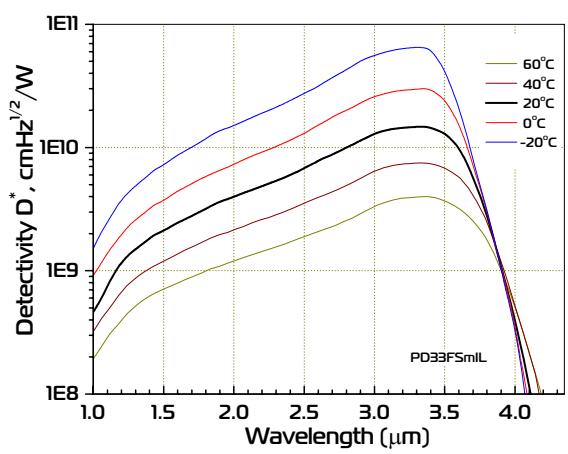
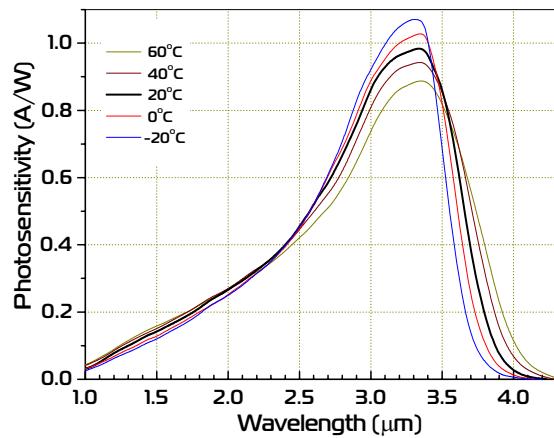
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Spectral response

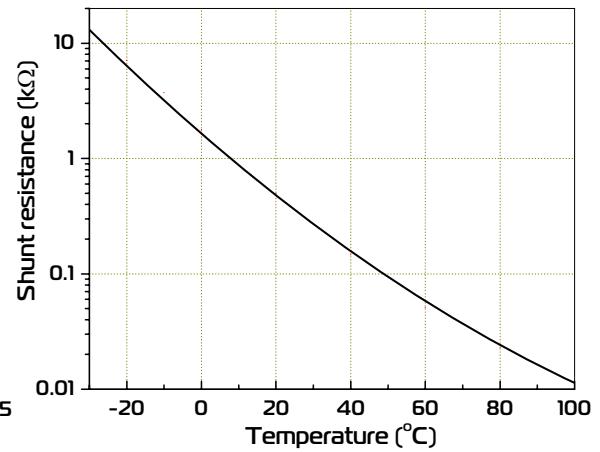
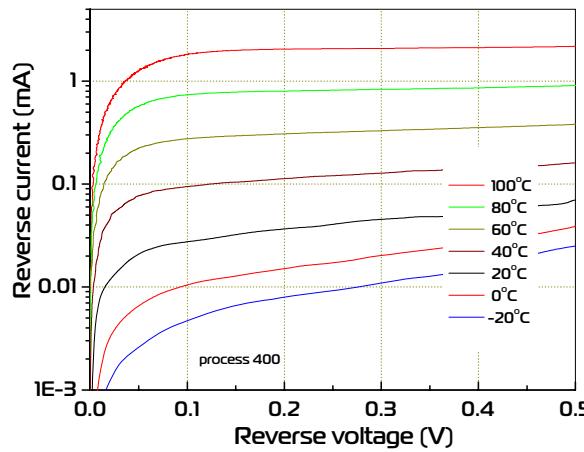
PD33FS



PD33FSmIL



Dark current vs. reverse voltage, shunt resistance vs. temperature



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Uncooled 4.1 μm FSI Photodiode PD41FS

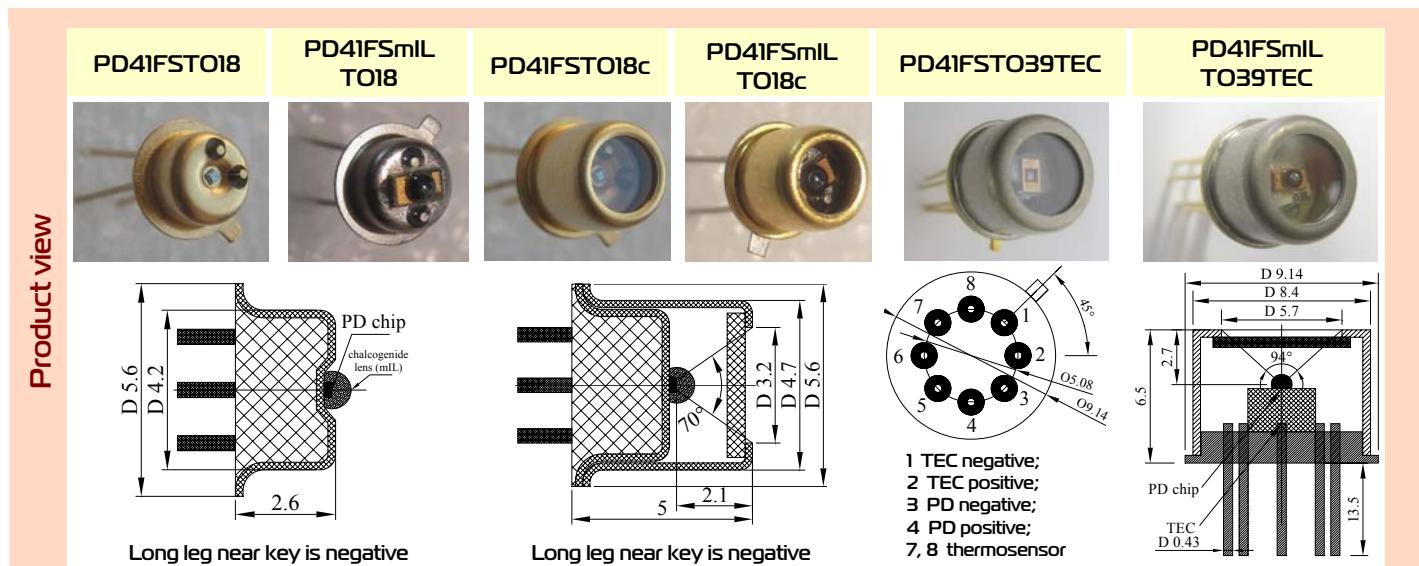
TE cooled 4.1 μm FSI Photodiode PD41FS TO39TEC

Uncooled 4.1 μm FSI Photodiode with microimmersion lens PD41FSmIL

TE cooled 4.1 μm FSI Photodiode with microimmersion lens PD41FSmIL TO39TEC

Peak wavelength	λ_{\max}	μm	4.15±0.05	@22 °C
Immersion lens			No	mIL
Current sensitivity	S_i	A/W	≥1 ^[1]	≥1
Shunt Resistance	R_o	Ohm	≥40	≥40
Detectivity	$D^*_{\lambda_{\max}}$	$\text{cmHz}^{1/2}\text{W}^{-1}$	≥1.5×10 ⁹	≥3×10 ⁹
Voltage sensitivity	S_u	V/W	≥40	≥40
Switching time	τ	ns	≤20	≤20

Code	Sensitive area, mm	Weight, g	Optical components	Field of view, deg.	Optical axis deviation, deg.	Detectivity deviation in lot, %	Operation conditions, °C
PD41FSTO18		~0.2	-	~140			
PD41FSTO18c	0.35×0.35	~0.3	sapphire window	~65	-	±25	-60÷+85
PD41FSTO39TEC		~1.2	sapphire window	~90			
PD41FSmILTO18		~0.2	-	~60			
PD41FSmILTO18c	~D=1	~0.3	sapphire window, chalcogenide lens	~60	≤5	±25	-60÷+60
PD41FSmILTO39TEC		~1.2	sapphire window, chalcogenide lens	~60			



Features

- Original growth of narrow gap A3B5 semiconductor alloys;
- Front side illuminated design of PDs;
- "Wide gap" window
- Optical coupling through the use of chalcogenide glass lenses (photodiode with microimmersion lens)
- Ambient and high temperature operation;
- No bias required;
- Operation from DC to VHF;
- Highest long term stability;
- High value of shunt resistance

Photodiode could be equipped with preamplifier that is designed for conversion of PD photocurrent into a convenient output voltage and is adjusted for the particular PD taking into account the R_o value and frequency range. Other packages are available upon request. Data are valid for PD thermostabilized at 22°C. Heatsink is essential for TEC operation!

Notes

¹ - process 6624

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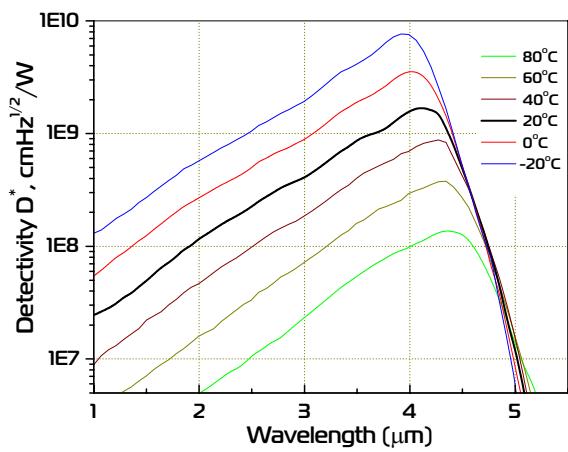
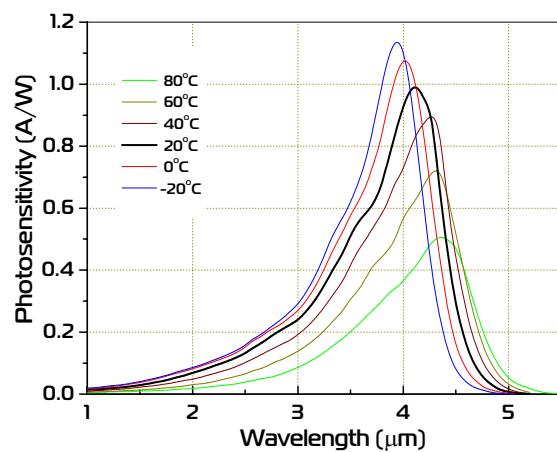
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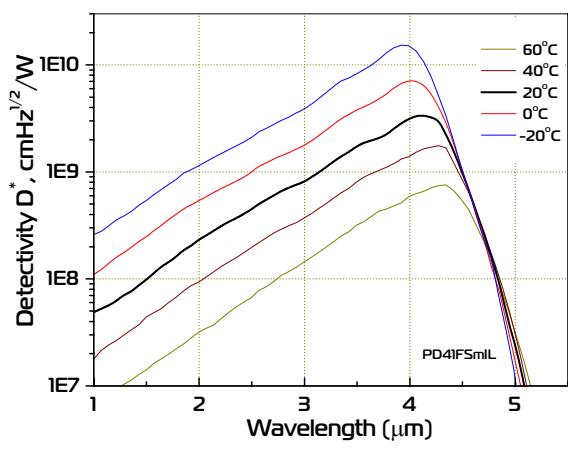
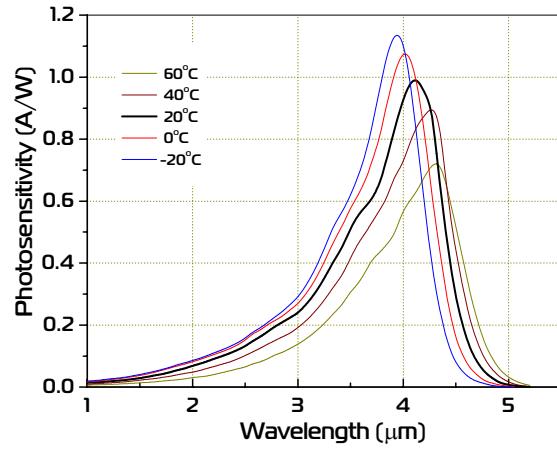
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<http://www.mirdog.spb.ru>; e-mail: bmat@iropt3.ioffe.ru

Spectral response

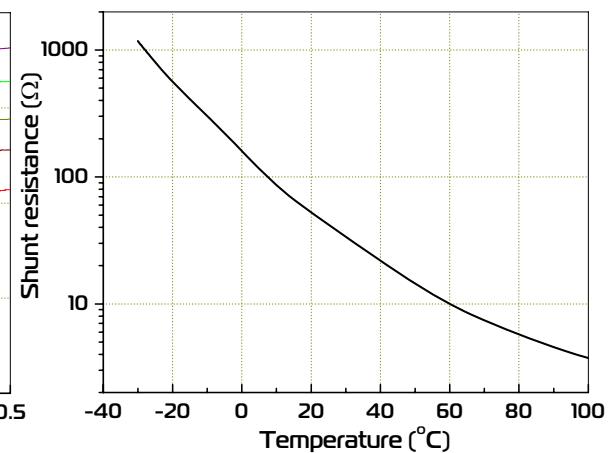
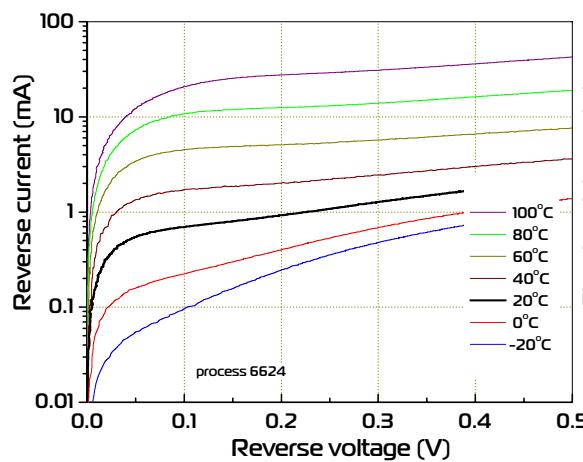
PD41FS



PD41FSmIL



Dark current vs. reverse voltage,
shunt resistance vs. temperature



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Uncooled 5.2 μm FSI Photodiode PD52FS

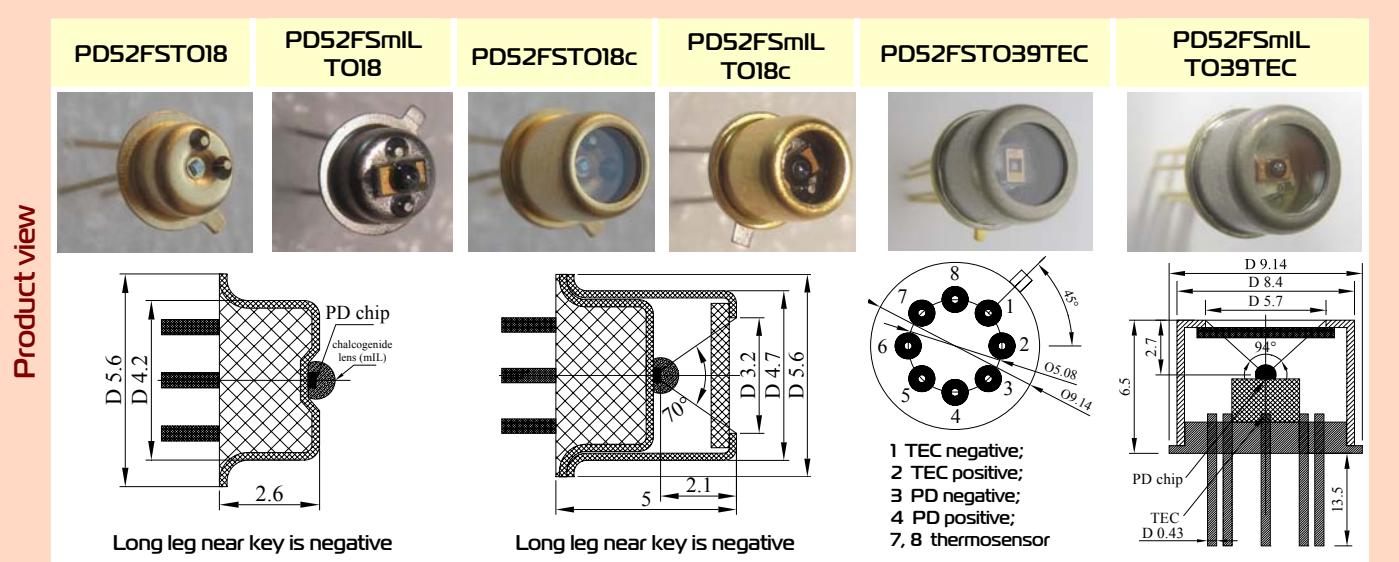
TE cooled 5.2 μm FSI Photodiode PD52FS TO39TEC

Uncooled 5.2 μm FSI Photodiode with microimmersion lens PDS2FSmIL

TE cooled 5.2 μm FSI Photodiode with microimmersion lens PDS2FSmIL TO39TEC

Peak wavelength	λ_{\max}	μm	5.2 ± 0.1	@22 °C
Immersion lens			No	mIL
Current sensitivity	S_i	A/W	≥ 0.3 ^[1]	≥ 0.3
Shunt Resistance	R_o	Ohm	≥ 1.5	≥ 1.5
Detectivity	$D^*_{\lambda_{\max}}$	$\text{cmHz}^{1/2}\text{W}^{-1}$	$\geq 1 \times 10^8$	$\geq 2 \times 10^8$
Voltage sensitivity	S_u	V/W	≥ 0.45	≥ 0.45
Switching time	τ	ns	≤ 50 ^[2]	≤ 50

Code	Sensitive area, mm	Weight, g	Optical components	Field of view, deg.	Optical axis deviation, deg.	Detectivity deviation in lot, %	Operation conditions, °C
PDS2FSTO18		~0.2	-	~140			
PDS2FSTO18c	0.35×0.35	~0.3	sapphire window	~65	-	±25	-60÷+85
PDS2FSTO39TEC		~1.2	sapphire window	~90			
PDS2FSmILTO18		~0.2	-	~60			
PDS2FSmILTO18c	~D=1	~0.3	sapphire window, chalcogenide lens	~60	≤5	±25	-60÷+60
PDS2FSmILTO39TEC		~1.2	sapphire window, chalcogenide lens	~60			



Features

- Original growth of narrow gap A385 semiconductor alloys;
- Front side illuminated design of PDs;
- "Wide gap" window
- Optical coupling through the use of chalcogenide glass lenses (photodiode with microimmersion lens)
- Ambient temperature operation;
- No bias required;
- Operation from DC to VHF;
- Highest long term stability;

Photodiode could be equipped with preamplifier that is designed for conversion of PD photocurrent into a convenient output voltage and is adjusted for the particular PD taking into account the R_o value and frequency range. Other packages are available upon request. Data are valid for PD thermostabilized at 22°C. Heatsink is essential for TEC operation!

Notes

¹ - process 6530(35)

² - according estimation

Product specifications are subject to change without prior notice due to improvements or other reasons. Updated 21.03.13



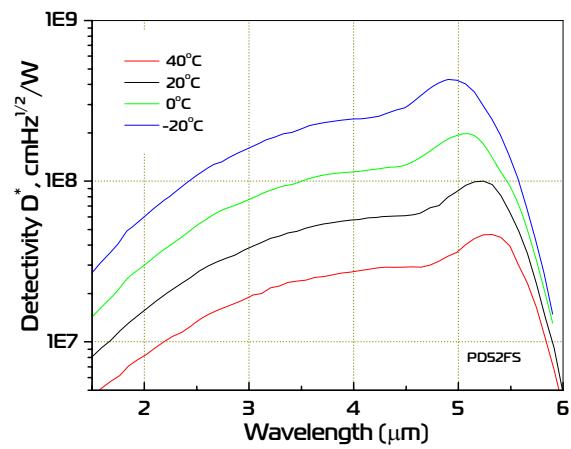
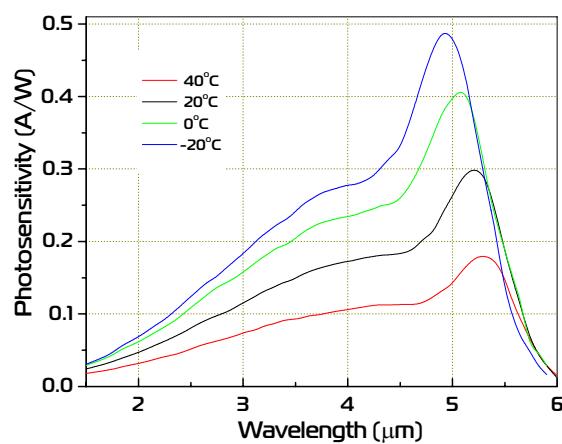
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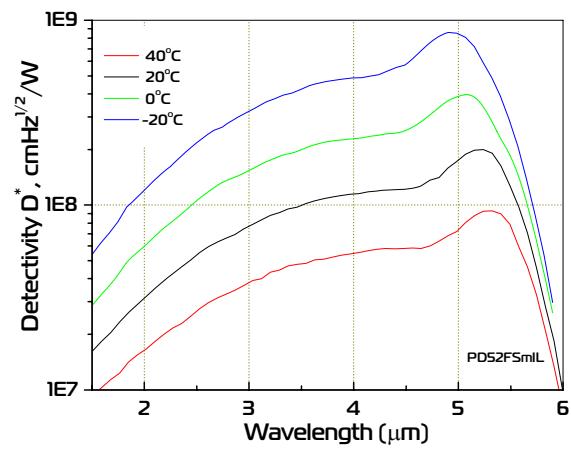
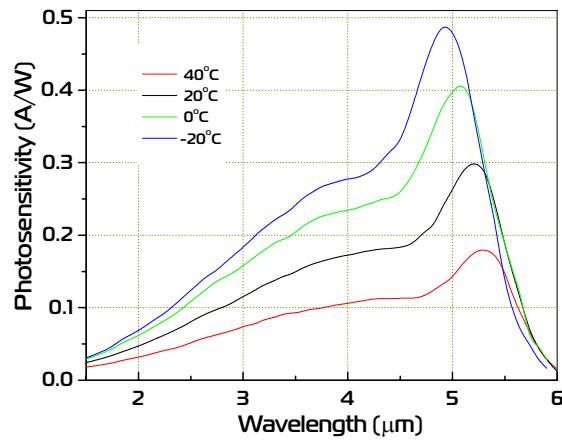
<http://www.ioffeled.com>; e-mail: Mremennyy@mail.ioffe.ru
<http://www.mirdog.spb.ru>; e-mail: bmat@iropt3.ioffe.ru

Spectral response

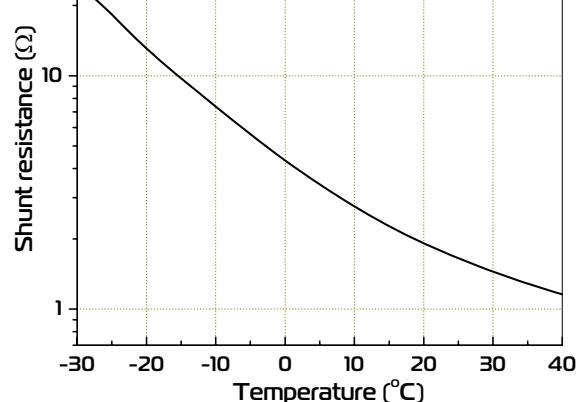
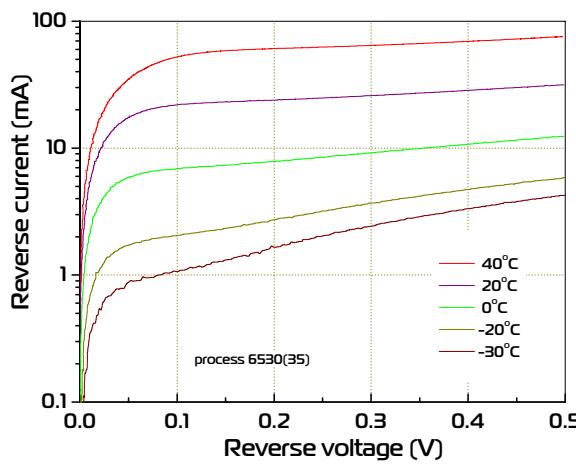
PDS2FS



PDS2FSmLL



Dark current vs. reverse voltage, shunt resistance vs. temperature



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Thermoelectric cooling module TO39TEC datasheet

Thermoelectric cooling module datasheet

Mounted TEC

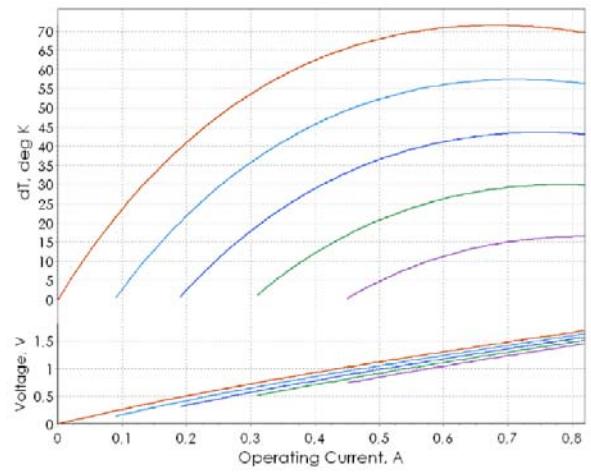
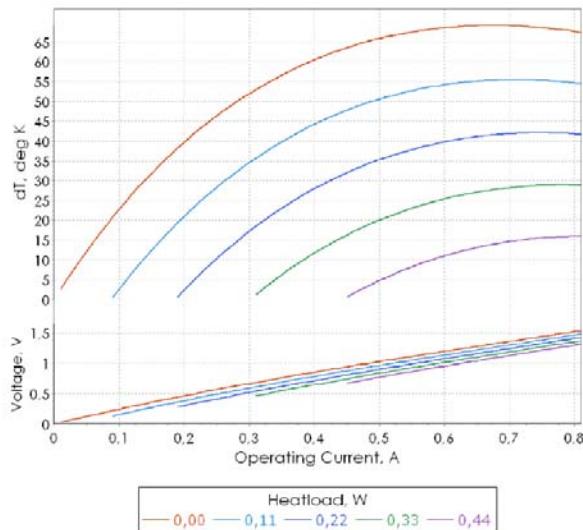
1MD04-011/10

@ 27 °C, Vacuum

ΔT_{max} , K	O_{max} , W	I_{max} , A	U_{max} , V
69	0.54	0.7	1.3

@ 50 °C, N2

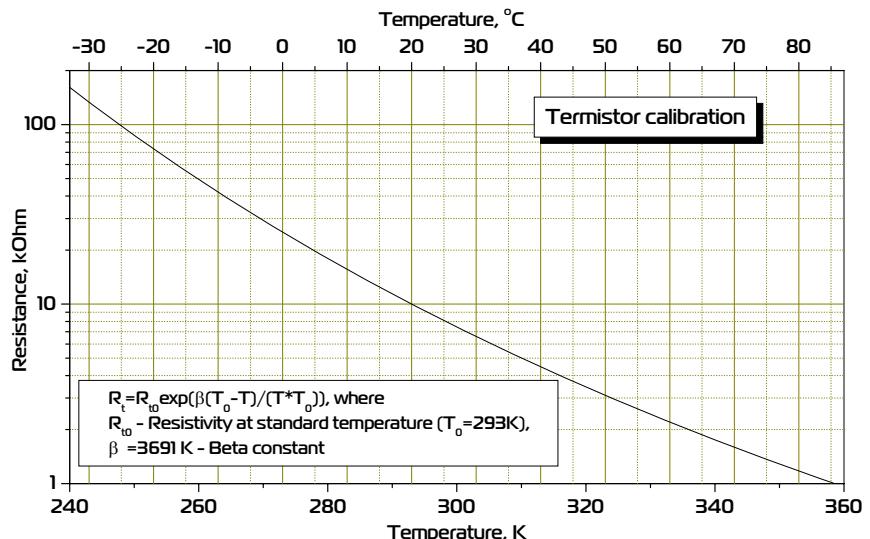
ΔT_{max} , K	O_{max} , W	I_{max} , A	U_{max} , V
72	0.6	0.7	1.4



Data from www.tec-microsystems.com; www.rmtltd.ru

Type TB04-103

T, °C	R, kΩ	T, °C	R, kΩ
-60	1134.5	15	12.44
-55	762.4	20	10.00
-50	521.6	25	8.09
-45	362.8	25	8.09
-40	256.3	30	6.60
-35	183.8	35	5.41
-30	133.6	40	4.47
-25	98.3	45	3.71
-20	73.3	50	3.10
-15	55.2	55	2.61
-10	42.1	60	2.20
-5	32.4	65	1.87
0	25.2	70	1.59
5	19.7	75	1.37
10	15.6	80	1.18



Thermistor specification



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Infrared detection modules PDMxx

Type	PDM34	PDM38	PDM42	PDM47	PDM55
Photodiode	PD34Sr	PD38Sr	PD42Sr	PD47Sr	PD55Sr
Peak wavelength, μm	3.4	3.8	4.2	4.7	5.3
Photosensitive area, mm/Field of view, deg.			$\varnothing 3.2 / \sim 15$		
Current/voltage conversion coefficient, V/A				2.5E5	
$U_{\text{rms}}, \text{mV}$				10÷20	
Maximum output voltage, V				4	
External power supply, V				+/- 5	
Frequency response, MHz				DC ÷ 1	
Thermistor			TB04-103, Resistance 10 kOhm at 20 °C		

Amplifier for MW IR photodiodes Ampxx

Frequency response, MHz	DC ÷ 1	Current/voltage conversion coefficient, V/A	2.5E5
$U_{\text{rms}}, \text{mV}$	10÷20		
Maximum output voltage, V	0÷4	External power supply, V	+/- 5

PDMxx

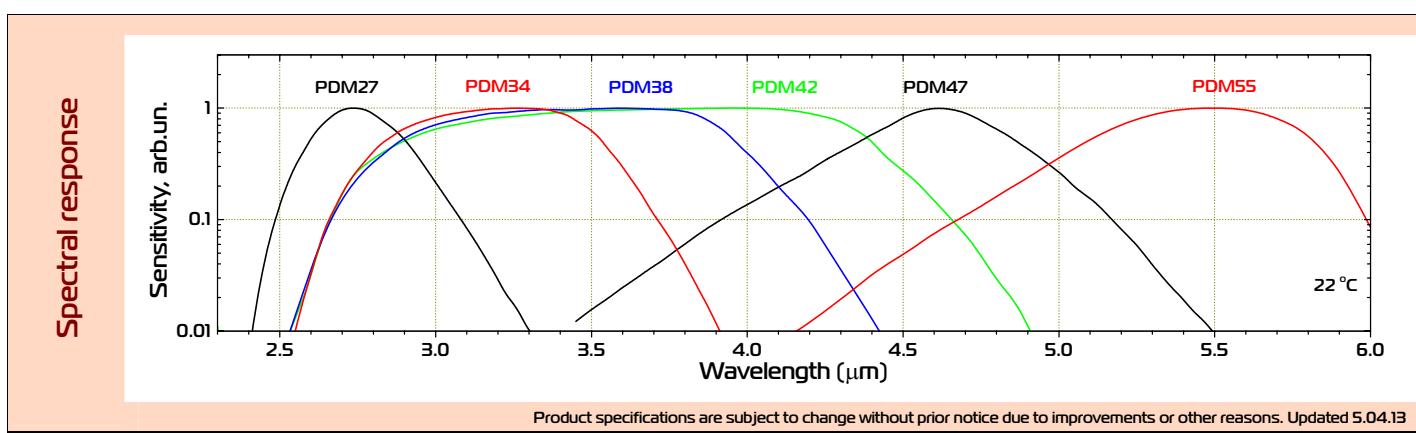
Ampxx

Product view

Features

Compact size; Uncooled detector; Easy to use; Operation from DC to HF; Highest long term stability

PDMxx are the infrared detection modules using an immersion photodiode, thermosensor and a transimpedance amplifier integrated into a compact case. PDMxx are dedicated to high speed and DC infrared measurements. Each amplifier is carefully optimized to work with particular type of photodiode.



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